Installation & Operation Manual

GF100 Series Metal Sealed, Thermal Mass Flow Controllers & Meters



Essential Instructions Read before proceeding!

Brooks Instrument designs, manufactures and tests its products to meet many national and international standards. These products must be properly installed, operated and maintained to ensure they continue to operate within their normal specifications. The following instructions must be adhered to and integrated into your safety program when installing, operating and maintaining Brooks Instrument products.

- To ensure proper performance, use qualified personnel to install, operate, update, program and maintain the product.
- Read all instructions prior to installing, operating and servicing the product. If this instruction manual is not the correct manual, please see back cover for local sales office contact information. Save this instruction manual for future reference.
- A WARNING: Do not operate this instrument in excess of the specifications listed in the Instruction and Operation Manual. Failure to heed this warning can result in serious personal injury and / or damage to the equipment.
- If you do not understand any of the instructions, contact your Brooks Instrument representative for clarification.
- · Follow all warnings, cautions and instructions marked on and supplied with the product.
- A WARNING: Prior to installation ensure this instrument has the required approval ratings to meet local and national codes. Failure to heed this warning can result in serious personal injury and / or damage to the equipment.
- Install your equipment as specified in the installation instructions of the appropriate instruction manual and per applicable local and national codes. Connect all products to the proper electrical and pressure sources.
- Operation: (1) Slowly initiate flow into the system. Open process valves slowly to avoid flow surges. (2) Check for leaks around the flow meter inlet and outlet connections. If no leaks are present, bring the system up to the operating pressure.
- Please make sure that the process line pressure is removed prior to service. When replacement parts are required, ensure that qualified people use
 replacement parts specified by Brooks Instrument. Unauthorized parts and procedures can affect the product's performance and place the safe
 operation of your process at risk. Look-alike substitutions may result in fire, electrical hazards or improper operation.
- Ensure that all equipment doors are closed and protective covers are in place to prevent electrical shock and personal injury, except when maintenance is being performed by qualified persons.
- A WARNING: For liquid flow devices, if the inlet and outlet valves adjacent to the devices are to be closed for any reason, the devices must be completely drained. Failure to do so may result in thermal expansion of the liquid that can rupture the device and may cause personal injury.

European Pressure Equipment Directive (PED)

All pressure equipment with an internal pressure greater than 0.5 bar (g) and a size larger than 25mm or 1" (inch) falls under the Pressure Equipment Directive (PED).

- The Specifications Section of this manual contains instructions related to the PED directive.
- Products described in this manual are in compliance with EN directive 2014/34/EU.
- All Brooks Instrument Flowmeters fall under fluid group 1.
- Products larger than 25mm or 1" (inch) are in compliance with PED category I, II or III.
- Products of 25mm or 1" (inch) or smaller are Sound Engineering Practice (SEP).

European Electromagnetic Compatibility (EMC)

The Brooks Instrument (electric/electronic) equipment bearing the CE mark has been successfully tested to the regulations of the Electro Magnetic Compatibility (EMC directive 2014/30/EU).

Special attention however is required when selecting the signal cable to be used with CE marked equipment.

Quality of the signal cable, cable glands and connectors:

Brooks Instrument supplies high quality cable(s) which meets the specifications for CE certification.

- If you provide your own signal cable you should use a cable which is overall completely screened with a 100% shield.
- "D" or "Circular" type connectors used should be shielded with a metal shield. If applicable, metal cable glands must be used providing cable screen clamping. The cable screen should be connected to the metal shell or gland and shielded at both ends over 360 Degrees.

The shield should be terminated to an earth ground.

Card Edge Connectors are standard non-metallic. The cables used must be screened with 100% shield to comply with CE certification.

The shield should be terminated to an earth ground.

For pin configuration : Please refer to the enclosed Instruction Manual.

ESD (Electrostatic Discharge)

A CAUTION: This instrument contains electronic components that are susceptible to damage by static electricity. Proper handling procedures must be observed during the removal, installation or other handling of internal circuit boards or devices.

Handling Procedure:

- 1. Power to unit must be removed.
- 2. Personnel must be grounded, via a wrist strap or other safe, suitable means before any printed circuit card or other internal device is installed, removed or adjusted.
- 3. Printed circuit cards must be transported in a conductive container. Boards must not be removed from protective enclosure until immediately before installation. Removed boards must immediately be placed in protective container for transport, storage or return to factory.

Comments

This instrument is not unique in its content of ESD (electrostatic discharge) sensitive components. Most modern electronic designs contain components that utilize metal oxide technology (NMOS, SMOS, etc.). Experience has proven that even small amounts of static electricity can damage or destroy these devices. Damaged components, even though they appear to function properly, exhibit early failure.

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Introduction

Designed for semiconductor, MOCVD, and other gas flow control applications that require a high purity all-metal flow path, the Brooks GF100 Series mass flow controllers and meters deliver outstanding performance, reliability, and flexibility. Process throughput and yield are maximized while process costs are reduced by the GF100 Series featuring:

- Ultra fast settling time for quick start up and very rapid process steps
- MultiFlo[™] gas and range configurability enabling reconfiguration without removing device from the gas line
- An independent diagnostic/service port to troubleshoot or change flow conditions without removing the mass flow controller from service

• Long-term stability due to extremely low wetted surface area, and corrosion resistant Hastelloy® sensor and valve seat

Optional model variations including—pressure transient insensitivity (PTI) and Safe Delivery System (SDS)



Figure 1-1 GF100 Series High Performance Gas Flow Controller Analog and Digital

How to Use This Manual

This manual is intended to provide the user with all the information necessary to install, operate, troubleshoot and maintain these thermal mass flow devices. The manual is organized in the following sections: Section 1 Introduction

Section 2 Installation

Section 3 Operation

- Section 4 Maintenance and Troubleshooting
- Section 5 Product Description Code

Appendix A GF100 Series Gas Table

Appendix B GF100 Series Patents

Appendix C Essential Instructions

Warranty, Local Sales/Service Contact Information

It is recommended that this manual be read in its entirety before attempting to operate or repair these devices.

Product Support	References
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Refer to www.BrooksInstrument.com for Brooks sales and service locations and to obtain other documents that support the GF100 Series. Those documents include:

- Brooks MultiFlo™ Configurator Quick Start Manual: X-SW-MultiFlo-Config-QS-eng. part Number 541B167AAG
- Brooks GF100 Series data sheets: DS-TMF-GF100-Series-MFC-eng DS-TMF-GF135-Series-MFC-eng DS-TMF-GF121-Series-MFC-eng DS-DPT-EtherCAT-GF100-Series-eng

Notice and Caution Statements

	Warning, caution and notice statements are located throughout this manual in the ANSI format. A WARNING statement indicates a potentially hazardous situation which, if not avoided, COULD result in death or serious injury. A CAUTION statement indicates a potentially hazardous situation which, if not avoided, MAY result in minor or moderate injury. It may also be used to alert against unsafe practices. A NOTICE statement describes specific information that requires special attention.
Product Warranty	
	Product warranty information can be found on the Back Cover of this Manual and on the Brooks website at www.BrooksInstrument.com . This information provides general warranty information, limitations, disclaimers, and applicable warranty periods according to product group.
How to Order a GF100 Series Device	e
	Refer to Section 5.
Industry Standard References	
	Refer to Table 1-1.
GF100 Series Gas Table	
Glossary of Terms and Acronyms	Refer to Appendix A.
	Refer to Table 1-2

Table 1-1 Industry Standard References

Reference Number	Reference Description			
MIL-STD-810	Method 514.4, Category 1, Transportation Requirement			
	Method 516.4, Procedure 1, Functional Shock Test Requirement			
SEMI E12	Standard temperature and pressure			
SEMI E16	Guideline for determining and describing MFC leak rates			
SEMI E17	Guideline for MFC transient characteristics tests			
SEMI E18	Guideline for temperature specifications of the MFC			
SEMI E27	Standard for MFC and MFM linearity			
SEMI E28	Guideline for pressure specifications for the MFC			
SEMI E52	Practice for referencing gases used in digital MFCs			
SEMI E54	Sensor actuator network connections for DeviceNet			
SEMI E56	Test method for detemining accuracy, linearity, repeatability, short-term			
	reproducibility, hystereses of thermal MFCs			
SEMI E66	Test method for determining particle contribution by MFCs			
SEMI E67	Test method for determining reliability of MFCs			
SEMI E68	Test method for determining warm-up time of MFCs			
SEMI E69	Test method for reproducibility and zero drift for thermal MFCs			
SEMI E80	Test method for determining attitude sensitivity of MFCs			
SEMI E16-90	Guidelines for determining and describing mass flow controllers leak rates			
SEMI F19	Specification for the finish of the wetted surface of electro polished			
02.001.00	216L stainless steel components			
SEMI F20	Specifications for 316L stainless steel bar, extruded shapes, plate, and			
02.007.20	investment castings for components used in ultra-high purity semi			
	manufacturing applications			
SEMI F36	Guide for dimensions and connections of gas distribution components			
SEMI F37	Method for determination of surface roughness parameters for gas			
SEMIT ST	distribution system components			
SEMI F44	Guideline for standardization of machined stainless steel weld fittings			
SEMI F45	Guideline for standardization of machined stainless steel reducing fittings			
SEMI F47	Specifications for semiconductor processing equipment			
05141.00	voltage sag immunity			
SEMI S2	Environmental, Health and Safety Guidelines			
SEMI S9	Dielectric testing			
SEMI S10	Risk assessment			
SEMI S12	Decontamination of fielded products			
ETG.1000.2	Physical Layer service definition and protocol specification			
ETG.1000.3	Data Link Layer service definition			
ETG.1000.4	Data Link Layer protocol specification			
ETG.1000.5	Application Layer service definition			
ETG.1000.6	Application layer protocol specification			
ETG.1020	EtherCAT Protocol Enhancements			
ETG.2000	EtherCAT Slave Information			
ETG.5001.1	Modular Device Profile - Part 1: General MDP Device Model			
ETG.5003.1	Semiconductor Device profile - Part 1: Common Device Profile (CDP)			
ETG.5003.2020	Specific Device Profile: Enhanced Mass Flow Controller			
ETG.5003.2021	Specific Device Profile: Mass Flow Controller			
ETG.5003.2022	Specific Device Profile: Mass Flow Meter			
ETG.5003.2023	Specific Device Profile: Enhanced Mass Flow Meter			

Term or Acronym	Definition	
CSR	Customer Special Requirement	
CVD	Chemical Vapor Deposition	
DeviceNet	A 5-wire local network I/O communication device that employs a command/response communication protocol	
DSP	Digital Signal Processor	
EPI Epitaxy (EPI).	A process technology where a pure silicon crystalline structure is deposited or "grown" on a bare wafer, enabling a high-purity starting point for building the semiconductor device.	
HBD	Horizontal Base Down	
GF100 Series	Integrated Flow Controller	
F.S.	Full Scale	
LED	Light Emitting Diode	
MFC	Mass Flow Controller	
MultiFlo Configurator	I/O communication software package that configures gas and flow ranges	
MultiFlo Technology	A physics-based calibration methodology that enables gas and flow range configuration within a defined standard configuration	
PID	Proportional Integral Derivative Controller	
PSIA	Pounds per Square Inch Absolute	
PSID	Pounds per Square Inch Differential	
PSIG	Pounds per Square Inch Gauge	
PTI	Pressure Transient Insensitive. Reduces the effect of pressure fluctuations in gas flow. Applicable to GF125 only.	
ROR	As pressure increases, flow increases at a pressure rate of rise, or ROR.	
HC	Standard Configuration w/ Hastelloy® sensors (to reduce reaction to corrosive gases)	
S.P.	Setpoint	
Step Technology	Enables fast set point control through a high speed DSP and low volume drive circuit	
VIU	Vertical mounting attitude with inlet side facing up	

Table 1-2 Terms and Acronyms

Description

Ultra Fast Response

The Brooks GF Series patented flow sensor combined with a high speed ARM processor and fast acting diaphragm-free valve assembly enables:

- · Faster response and settling time for improved wafer throughput
- Ultra-fast 1-2 second etch step processing
- Reduced diverted gas consumption and associated abatement costs
- Time sensitive gas delivery steps in Atomic Layer Deposition

• User programmable start-up function for processes requiring a slow ramped gas turn-on or time critical transitions between flow rates

MultiFlo[™] Gas and Range Configurability

The Brooks MultiFlo technology delivers exceptional improvement in process gas accuracy for linear and non-linear gases. This is achieved through advanced gas modeling and optimized through actual gas testing. Brooks MultiFlo[™] allows the device to be quickly and easily configured for another gas and/or flow range without sacrificing accuracy or rangability. Selecting a new gas automatically creates a new calibration curve, establishes optimized PID settings for dynamic control, automatically compensates for gas density effects, and ensures smooth overshoot-free transitions between flow rates with excellent steady-state stability. Brooks MultiFlo technology offers unparalleled flexibility. An extensive gas database is provided and a single device can be quickly programmed for thousands of different gas and flow range combinations. Process benefits achieved:

• Mass flow controller full scale full range can be rescaled down typically by a factor of 3:1 with no impact on accuracy, turndown or leak by specifications

Optimum process and inventory flexibility resulting in dramatically reduced inventory costs

- · Fewer configurations/bin sizes required to support many different processes
- · Less down-time with rapid process recovery

MultiFlo[™] Support References: Brooks MultiFlow Configurator Quick Start Guide (X-SW-MultiFlo-Config-QS-eng (Part Number: 541B167AAG))

MultiFlo[™] Configurator Accessory Kits:

778Z010ZZZ	Basic MultiFlo Configurator Kit
	*Software, MultiFlo Configurator
A331710003	Cable Assembly 2.5mm
214F027AAA	USB-RS485 Converter with DB-9 female
778Z011ZZZ	Basic MultiFlo Configurator Kit w/Power Supply and Adapter Cables *Software, MultiFlo Configurator
A331710003	Cable Assembly 2.5mm
214F027AAA	USB-RS485 Converter with DB-9 female
A332295001	Power Supply MFC
A332297002	Cable, Power, 9-Pin
A332297001	Cable, Power, DeviceNet
	igurator Software is available on the Brooks Instrument <u>w.BrooksInstrument.com/MultiFlo</u>
www.BrooksIns	strument.com/Documentation&Downloads

Pressure Transient Insensitivity (PTI)— Included with all GF125 & GF135 models

Cost and space constraints are driving gas panel designers to remove point-of-use pressure regulators and pressure monitoring components from the process design and rely solely on the mass flow controller to accurately control the process under dynamic pressure conditions. The Brooks GF125 & GF135 (PTI) devices utilize a patented control algorithm that inverts the pressure signal, compares it to the pre-fluctuation signal and drives realtime valve position compensation to maintain stable flow. Enhanced pressure transient is achieved through faster sensing, quicker processing, and a reduction in internal dead-volume between the sensors and valve orifice.

GF101/121/126 based on the same technology and design as the low flow GF's (same sensor, same electronics, low power support)

- · Smaller footprint than competitive MFC's
- · Handles flow rates up to 300 slpm
- Metal seal for durability and high leak integrity
- Proprietary sensor technology
- · Precise flow control with fast sub-1 second settling time
- 1% of reading accuracy
- Corrosion-resistant Hastelloy C-22 sensor tube

Optional Safe Delivery System (SDS)— GF120 model only

The Safe Delivery System (SDS) enhanced GF120 model is a state-of-theart low pressure drop devices for the delivery of sub atmospheric safe delivery system gases used in Implant and Etch processes. The Brooks GF120 SDS models are available in full scale flow ranges 4 sccm -1 slpm.

Advanced Thermal Flow Measurement Sensor

Brooks proprietary highly corrosion resistant Hastelloy C-22 sensor with an enhanced sensor manufacturing and burn in process incorporates a unique orthogonal sensor mounting orientation to eliminate sensor drift caused by valve heating effects and eliminates thermal siphoning effects. This unique sensor configuration includes an optimized temperature profile for gases prone to thermal decomposition. This design results in:

 Enhanced signal to noise performance for improved accuracy at low set points

• Superior reproducibility at elevated temperature through new isothermal packaging and onboard conditioning electronics with ambient temperature sensing and compensation

Improved long-term stability

High Purity Flow Path

The Brooks GF Series has an all metal, corrosion resistant Semi F20 compliant wetted flow path with highly corrosion resistant Hastelloy C-22 valve seat and jet orifice. The GF120, GF125 & GF135 devices are constructed with a 4μ inch Ra max surface finish while the GF100 is constructed with a 10μ inch Ra.

• Overall reduced surface area and un-swept volumes for faster dry-down during purge steps

· Long-term sensor and device stability for maximum yield and throughput

Extensive Mechanical Configurations

GF Series supports all metal seal/UHP industry gas connection interface standards for full OEM and process coverage.

• Downport 79.8mm and 92mm C-seal and W-seal on 1-1/8" and 1-1/2" bodies

• 124mm 4 VCR on 1-1/2" body



Figure 1-2 LCD Display

Enhanced Diagnostics and User Interface

The mass flow controller is one of the most complex and critical components in gas delivery systems. When dealing with ultra-high-purity gas distribution or highly toxic or corrosive gases, removing the mass flow controller to assess functionality should be the last resort. Brooks GF Series devices provide for in-line device evaluation and instantaneous troubleshooting through:

· Embedded self test routines and independent diagnostic/service port

• High visibility LCD display with easy accessible push button for local indication of Flow (%), Temperature (°C), Pressure (PSIA/kPa) and Network Address

• Zero button to easily re-zero the device during scheduled maintenance

• Rotatable display with a push button to enable improved readability based on how the MFC is mounted. Simply hold button down for at least 3 seconds to rotate display. This featue is standard for GF135 and GF101/GF121/GF126 and available for GF100/GF120/GF125.

This combination of features results in limiting service interruption and reduced downtime.

Communication Interfaces

The GF100 Series supports analog 0-5 Vdc, RS485, DeviceNet[™] and EtherCAT[®] communication protocols. Analog connections can be accessed via the DeviceNet or RS485 or Analog only connector options. DeviceNet and RS485 are multi-drop connections that allow a maximum of 64 devices for DeviceNet and 32 devices for RS485 to be connected on the same network. Brooks Instrument's DeviceNet profile has been certified by the ODVA[™] (Open DeviceNet Vendor's Association). EtherCAT is an Ethernet based communications system know for its high cycle time and cost efficient cabling and master application solutions. The EtherCAT GF100 Series devices conform to the ETG.5003 Semiconductor Device Profile specification. A range of low profile adapter cables facilitate replacing previously installed devices eliminating the need to carry multiple devices of the same gas/range but different electrical connectors.

Specifications for GF100 Series Devices

Do not operate this instrument in excess of the specifications listed below. Failure to heed this warning can result in serious personal injury and/or damage to the equipment.

It is the user's responsibility to select and approve all materials of construction. Careful attention to metallurgy, engineered materials and elastomeric materials is critical to safe operation.

See Table 1-3 for specifications for standard GF100 Series.

See Table 1-4 for specifications for the Safe Delivery System (SDS) GF120 Series.

See Table 1-5 for specifications for standard GF100 Series-EtherCAT

See Table 1-6 for specifications for the GF135 Series.

See Table 1-7 for specifications for the GF121 Series.

See Table 1-8 for specifications for the GF121 Series-EtherCAT

See Figure 1-3 for dimensions for the GF100 Series.

See Figures 1-4 & 1-5 for dimensions for the GF135 Series.

See Figure 1-6 for dimensions for the GF121 Series.

See Figure 1-7 for dimensions for the GF100/GF121 Series-EtherCAT

Able 1-3 Specifications for Stan Performance	GF100	GF120	GF125		
Full Scale Flow Range (N ₂ Eq.)		3 sccm to 55 slm			
Flow Accuracy	±1% S.P. > 35-100%, ±0.35% F.S. 2-35%				
Repeatability & Reproducibility		< ± 0.15% S.P.			
Linearity	± 0.5%	F.S. (included in accuracy)			
Response Time (Settling Time) Normally Closed Valve	< 1 sec	700ms	300ms (3-860 sccm N2 Eq.) 400ms (861-7200 sccm N2 Eq.) 500ms (7201-30000 sccm N2 Eq.) <700ms (30001-55000 sccm N2 Eq.)		
Normally Open Valve		<1.5 sec	· · · - · · · · · · · · · · · · ·		
Pressure Insensitivity	Not	Applicable	< 5% SP up to 5 psi/sec upstream press. spike		
Control Range	2-100% (Normally Clo	osed Valve) 3-100% (No	ormally Open Valve)		
MultiFlo		standard			
#of Bins		11 bins			
Valve Shut Down (N.C. Valve) Valve Shut Down (N.O. Valve)		< 1% of F.S. 2% of F.S.			
Zero Stability		< <u>+</u> 0.5% F.S. per year	1		
Temperature Coefficient	Span:	: 0.05% S.P. per °C, Zero: 0.00	95% F.S. per ℃		
Ratings					
Operating Temperature Range		10-50°C			
Differential Pressure Range*	3-860 sccm = 7-45 psid, 861- 7200 sccm = 10-45 psid, 7201-55000 sccm = 15-45 psid *Argon gas applications require an additional 10 psid differential pressure. Low vapor pressure gases require an inlet pressure of > 100 Torr, with vacuum on outlet (example SiCl4). Contact Brooks Technical Support for more information.				
Maximum Operating Pressure	500	psia max	100 psia max		
Leak Integrity (external)		1x10 ⁻¹⁰ atm. cc/sec He			
Mechanical					
Valve Type	Normally Closed Normally Open Meter (no valve)				
Wetted Materials			Stainless Steel, 304 Stainless Steel, KM-45 22, 316L Stainless Steel, 304 Stainless Steel, KM-45		
Surface Finish	10µ inch Ra		4μ inch Ra (0.1 μm Ra)		
Diagnostics & Display Status Lights		MFC Health, Networl	< Status		
Alarms	Control Valve Output, Network Interruption				
maillis	Top Mount Integrated LCD Fixed / 10 feet Flow (%), Temp. (°C), Pressure (psia, kPa) / 0.1 (unit)				
Atarms Display Type Viewing Angle / Viewing Distance Units Displayed / Resolution	Fixed / 10 feet		nterruption		
Display Type Viewing Angle / Viewing Distance Units Displayed / Resolution Electrical	Fixed / 10 feet Flow (%), Temp. (°C), Pressure (psi	a, kPa) / 0.1 (unit)	·		
Display Type Viewing Angle / Viewing Distance Units Displayed / Resolution	Fixed / 10 feet Flow (%), Temp. (°C), Pressure (psi RS485/Analog via 9-Pin "D" conne	a, kPa) / 0.1 (unit) ector, DeviceNet™via 5-Pin ″M	12" connector		
Display Type Viewing Angle / Viewing Distance Units Displayed / Resolution Electrical	Fixed / 10 feet Flow (%), Temp. (°C), Pressure (psi	a, kPa) / 0.1 (unit) ector, DeviceNet™via 5-Pin ″M	12" connector		
Display Type Viewing Angle / Viewing Distance Units Displayed / Resolution Electrical Electrical Connection	Fixed / 10 feet Flow (%), Temp. (°C), Pressure (psi RS485/Analog via 9-Pin "D" conne	a, kPa) / 0.1 (unit) ector, DeviceNet™via 5-Pin ″M	12" connector		
Display Type Viewing Angle / Viewing Distance Units Displayed / Resolution Electrical Electrical Connection Digital Communication	Fixed / 10 feet Flow (%), Temp. (°C), Pressure (psi RS485/Analog via 9-Pin "D" conne RS485+ (model specific), DeviceNet	a, kPa) / 0.1 (unit) ector, DeviceNet [™] via 5-Pin "M (model specific), RS485 Diagno Vdc., 250mA max. @ 24Vdc	12″ connector stic Port (all models)		
Display Type Viewing Angle / Viewing Distance Units Displayed / Resolution Electrical Electrical Connection Digital Communication Diagnostic /Service Port	Fixed / 10 feet Flow (%), Temp. (°C), Pressure (psi RS485/Analog via 9-Pin "D" conne RS485+ (model specific), DeviceNet RS485 via 2.5mm jack DeviceNet: 545mA max. @ +11-25	a, kPa) / 0.1 (unit) ector, DeviceNet [™] via 5-Pin "M (model specific), RS485 Diagno Vdc., 250mA max. @ 24Vdc Vdc. (±10%) or +24 Vdc (±10%	12″ connector stic Port (all models) ⁄o)		

Table 1-3 Specifications for Standard GF100/GF120/GF125 Series

_			
Performance	GF120XSL GF120XSD		
Full Scale Flow Range (N ₂ Eq.)	4 - 25 sccm >25 to 1 slpm		
Gases Supported	AsH ₃ , PH ₃ , BF ₃ , SiF ₄ , Ar, Xe, N ₂ O, N ₂ , GeF4, AsF5, PF3,		
	H2Se, HMDSO, HMDSN, H2O***		
MultiFlo Programmable	Not Configurable		
Flow Accuracy	+/-1% S.P.≥35% F.S. +/-0.35% F.S. <35% F.S.		
Repeatability & Reproducibility	<+/- 0.15% S.P.		
Zero Stability	<=0.6% F.S. per year		
Settling Time (to within $\pm 2\%$ F.S.)	< 3 sec		
Warm Up Time	minimum of 30 minutes		
Leak Integrity	1X10 ⁻¹¹ atm. cc/sec He		
Valve Shut Down (Leaky by)	<1% F.S.		

Table 1-4 Specifications for Safe Delivery System (SDS) GF120 Series

Operating Conditions	GF120XSD	GF120XSL
Minimum Operating Inlet Pressure*	4 to 20 sccm ≤ 10 Torr	
	>20 to 50 sccm \leq 20 Torr	
	>50 sccm to 1 slpm \leq 50 Torr	
Maximum Pressure	500 psia max	
Pressure Insensitivity	Not Available	
DifferentialPressure**	10 Torr-30 psid typical (1.33-207 kPa typical)	
Valve Configuration	Normally Closed	
Ambient Temperature Range	10°C-50°C	
Zero Temperature Coefficient	Span: 0.05% SP per °C, Zero: 0.005% F.S. per °C	

*Performance at minimum inlet pressure will be gas and flow range dependent. Consult Technical Support for details.

Typical pressure drop. Actual pressure drop will be gas and flow dependent. Consult Technical Support for details. *Consult factory for other gases.

Performance	GF100	GF120	GF125	GF120XSL	GF120XSD
Full Scale Flow Range		3 sccm to 55 slm		4 sccm to 25 sccm	>25 sccm to 1 slpm
Flow Accuracy	<u>+</u> 1% S.	<u>±</u> 1% S.P. > 20-100%; <u>±</u> 0.2% F.S. 2-20%		±1% S.P. 35-100%; ±0.35% F.S. 2-35%	
Repeatability & Reproducibility	< <u>±</u> 0.15% S.P.				
Flow Settling Time (NC Valve)	< 1 sec	700ms	300ms (3-860 sccm N2 Eq.) 400ms (861-7200 sccm N2 Eq.) 500ms (7201-30000 sccm N2 Eq.) <700ms (30001-55000 sccm N2 Eq.)	< 3 sec	
Flow Settling Time (NO Valve)		<1.5 sec			
Pressure Insensitivity	Not Ap	plicable	< 1% S.P. up to 5 psi/sec upstream press. spike		
Control Range		100% (Normally Closed V 100% (Normally Open Va		2-100% (Normally Closed Valve)	
MultiFlo		Standard			
#of Bins		11 bins			
Valve Shut Down (N.C. Valve)		0.15% of F.S.		<1%	of F.S.
Valve Shut Down (N.O. Valve)		2% of F.S.			
Zero Stability		< <u>+</u> 0.15% F.S. per year		< <u>+</u> 0.6%	F.S. per year
Temperature Coefficient		Zero: 0.005% F.S. per °C		Zero 0.005	% of F.S. per °C
atings Operating Temperature Range			10-50°C		
Differential Pressure Range*	3-860 sccm = 7-45 psid 861- 7200 sccm = 10-45 psid 7201-55000 sccm = 15-45 psid		10 Torr - 30 psid typical For more details consult factory		
Maximum Operating Pressure	500 ps	ia max	100 psia max	up to 500 psia max	
Leak Integrity (external)	1x10^-10 atm. cc/sec He				
Nechanical					
Valve Type	Normally Closed Normally Open Meter (no valve)			Normally Closed	
Wetted Materials	SEMI F20 HP C	ompliant, 316L VIMVAR, Has	telloy C-22, 316L Stainless Steel,	304 Stainless Steel, KM	-45
Surface Finish	10µ inch Ra	5µ inc	n Ra	5µ in	ich Ra
iagnostics & Display					
Status Lights		R	un, Error, Power, Network Stat	us	
Alarms	Control Valve Out	put, Network Interruption,	Temperature High/Low, Press	ure High/Low, Power S	urge/Sag
Display Type			Top Mount Integrated LCD		-
Viewing Angle / Viewing Distance			Rotatable / 10 feet		
Units Displayed / Resolution	Flow (%), Temp. (°C), Pressure (psia, kPa) / 0.1 (unit)				
Electrical					
Electrical Connection	Power via 5-pin M8 Connector, EtherCAT via R]45 jacks				
Digital Communication			EtherCAT		
Diagnostic /Service Port			Micro-USB		
Power Supply/Consumption		320 mA max. @ 18-30 Vdc	, 230 mA max. @ 24 Vdc (unde	r typical operating con	ditions)
Compliance					
EMC Environmental Compliance	EMC Directive 2014/30 RoHS Directive (2011/6	/EU Evaluation Standard E 55/EU)	N61326-1:2013		

Table 1-5 Specifications for GF100/GF120/GF125 Series with EtherCAT Communications

*Argon gas applications require an additional 10 psid differential pressure. Low vapor pressure gases require an inlet pressure of > 100 Torr, with vacuum on outlet (example SiCl4). Contact Brooks Technical Support for more information.

Table 1-6 Specifications for GF135 Series Performance

Full Scale Flow Range:	3 sccm to 5 slm (N2 Eq.)			
Gasses Supported:	N2, O2, Ar, H2, SF6, NH3, CO2, Cl2, HBr, NF3, CF4, CH4, CH3F, CH2F2, SiCl4 (@ 100 Torr), C4F6-q (@ 800 Torr), C4F8 (@ 1200 Torr), N2O, CHF3, SiH2Cl2, C5F8, He			
Flow Accuracy:	+/-1.0% S.P. (10-100% F.S.), +/-1% S.P. plus +/-0.04% F.S. (2-10% F.S.)			
Repeatability & Reproducibility:	< +/- 0.15% S.P.			
Linearity:	Included in accuracy			
Settling Time (to within +/-2% FS):	<300ms (<860 sccm N2 Equivalent), <400ms (861-5000 sccm N2 Equivalent)			
Pressure Insensitivity:	< 1% S.P. up to 5 psi/sec upstream press. spike			
Control Range:	1-100%			
Valve Shut Down:	< 0.5% of F.S. N2			
Zero Stability:	< +/- 0.5% F.S. per year			
Temperature Coefficient:	Span: 0.05% setpoint per °C, Zero: 0.005% F.S. per °C			
Rate-of-Decay Performance:	(ROD by default is disabled/off. It should not be enabled until after MFC is installed and properly commissioned)			
Flow Rate:	Maximum flow rate for which an ROD measurement can be obtained is 800 sccm			
Temperature Sensitivity:	+/- 0.04% S.P./Deg C			
Pressure Sensitivity:	+/- 0.04% F.S./psi			
Minimum Detectable Change from Commissioning Baseline:	Zero Drift: +/- 0.02% F.S. Valve Leak: +0.1% F.S.			
-	Repeatability: +/- 0.3% S.P. (SiCl4 +/- 0.5% from 5-100% S.P. up to 100 sccm flow)			

Ratings

Operating Temperature Range:	10-50°C		
Differential Pressure Range**:	3-860 sccm = 7-45 psid, 861- 5000 sccm = 10-45 psid **Typical pressure drop. Actual pressure drop will be gas and flow dependent. Argon gas applications require higher differential pressure. Low vapor pressure gases require an inlet pressure of > 100 Torr, with vacuum on outlet (example SiCl4). Contact Brooks Technical Support for more information.		
Maximum Operating Pressure:	100 psia max		
Pneumatic Valve Operating Pressure:	43.5 psia - 72.5 psia		
Leak Integrity (external):	1x10-10 atm. cc/sec He		

Mechanical

Valve Type:	Normally Closed
Wetted Materials:	SEMI F20 UHP Compliant 316L VIM/VAR, Hastelloy C-22,316L Stainless Steel, 304 Stainless Steel, KM-45
Surface Finish:	4μ inch Ra (0.1 μm Ra)

Diagnostics & Display

Status Lights:	MFC Health, Network Status		
Alarms:	Sensor Output, Control Valve Output, Over Temperature, Power Surge/Sag, Network Interruption, Sensor Drift, Flow Error, Valve Leak		
Display Type:	Top Mount Electronically Rotatable Integrated LCD		
Viewing Distance:	Fixed / 10 feet		
Units Displayed / Resolution:	Flow (%), Temp. (°C), Pressure (psia, kPa) / 0.1 (unit)		

Electrical

Electrical Connection:	Analog/RS-485 via 9-Pin "D" connector, DeviceNet via 5-Pin "M12" connector		
Digital Communication:	RS485+ (model specific), DeviceNet (model specific), RS485 Diagnostic Port (all models)		
Diagnostic / Service Port:	RS485 via 2.5 mm jack		
Power Supply/Consumption:	DeviceNet: +11-25 Vdc., 545 mA max. @ 11 Vdc., 250 mA (max.) @ 24 Vdc.,		
	Analog /RS485: +/-15 Vdc. (+10%), 6 Watts (max) or +24 Vdc +/-10%		

Compliance

EMC	EC Directive 2004/108/EC CE: EN61326: 2006 (FCC Part 15 & Canada IC-subset of CE testing)			
Environmental Compliance	RoHS Directive 2011/65/2006			
	Reach Directive EC 1907/2006			

Table 1-7 Specifications for GF101/GF121/GF126 Series

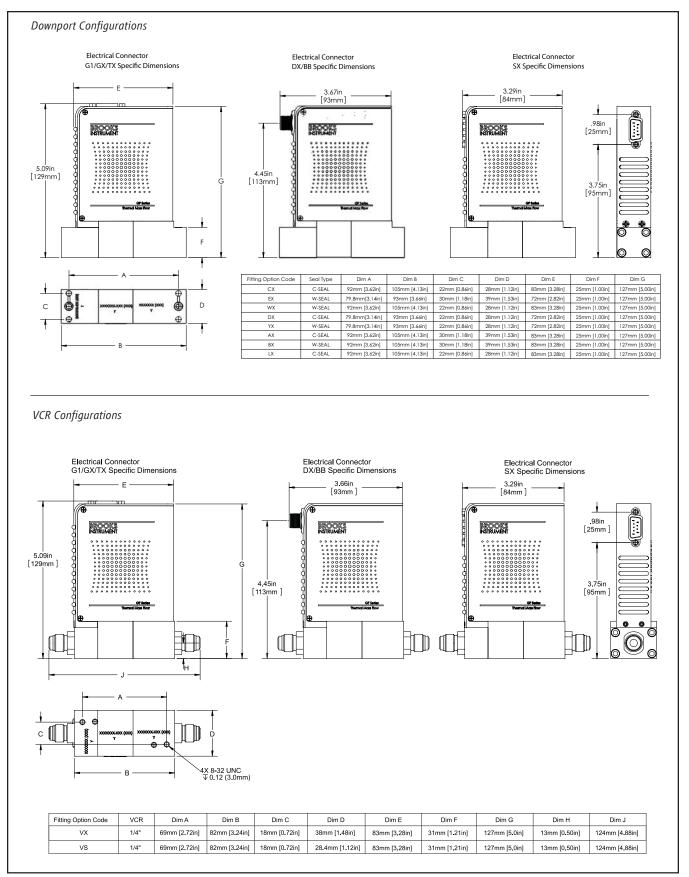
Performance	GF101	GF121	GF126			
Full Scale Flow Range (N ₂ Eq.)		55 to 300 slm				
Flow Accuracy	±1% S.P. > 35-100%, ±0.35% F.S. 2-35%					
Repeatability & Reproducibility	< <u>±</u> 0.15% S.P.					
Linearity		± 0.5% F.S. (included in accuracy)				
Response Time (Settling Time) Normally Closed Valve		< 1 sec				
Pressure Transducer			Ability to measure inlet pressure			
Control Range		5-100% (Normally Closed V	alve)			
MultiFlo		Standard (All typical high flow r	rate process gases & mixtures supported)			
# of Bins		4 Bins				
Control Range		5-100% (Normally Closed V	alve)			
Valve Shut Down (N.C. Valve)		< 2% of F.S. @ 30 N2 psig/a	tm out			
Zero Stability		< <u>+</u> 0.5% F.S. per year				
Temperature Coefficient	Sp	an: 0.05% S.P. per °C, Zero: 0.005%	% F.S. per ℃			
Ratings						
Operating Temperature Range	10-50°C					
Differential Pressure Range		30-90 psid				
Maximum Operating Pressure	Controller: 75 psig / Meter: 150 psig					
Leak Integrity (external)	1x10 ⁻¹⁰ atm. cc/sec He					
Mechanical						
Valve Type	Normally Closed Meter (no valve)					
Wetted Materials		. VIMVAR, Hastelloy C-22, 316L Stainles ant, 316L VIMVAR, Hastelloy C-22, 316I	s Steel, 304 Stainless Steel, KM-45 Stainless Steel, 304 Stainless Steel, KM-45			
Surface Finish	10µ inch Ra	5μ i	nch Ra (0.1 μm Ra)			
Diagnostics & Display						
Status Lights	MFC Health, Network Status					
Alarms	Control Valve Output, Network Int	erruption				
Display Type Viewing Angle / Viewing Distance Units Displayed / Resolution	Top Mount Integrated LCD Fixed / 10 feet Flow (%), Temp. (°C), Pressure (psia, kPa) / 0.1 (unit)					
Electrical						
Electrical Connection	RS485/Analog via 9-Pin "D" conn	ector, DeviceNet™ via 5-Pin "M12" (connector			
Digital Communication	RS485+ (model specific), DeviceNet (model specific), RS485 Diagnostic Port (all models)					
Diagnostic /Service Port	RS485 via 2.5mm jack					
Power Supply/Consumption	DeviceNet: 545 mA max. @ +11-25 Vdc., 250mA max. @ 24 Vdc (Under typical operating conditions) RS485/Analog: 6 Watts max @ ±15 Vdc. (±10%) (Under typical operating conditions)					
Compliance						
EMC Environmental Compliance	RoHS Directive (2011/65/EU)	61326: 2006 (FCC Part 15 & Canad	a IC-subset of CE testing)			
	REACH Directive EC 1907/2006					

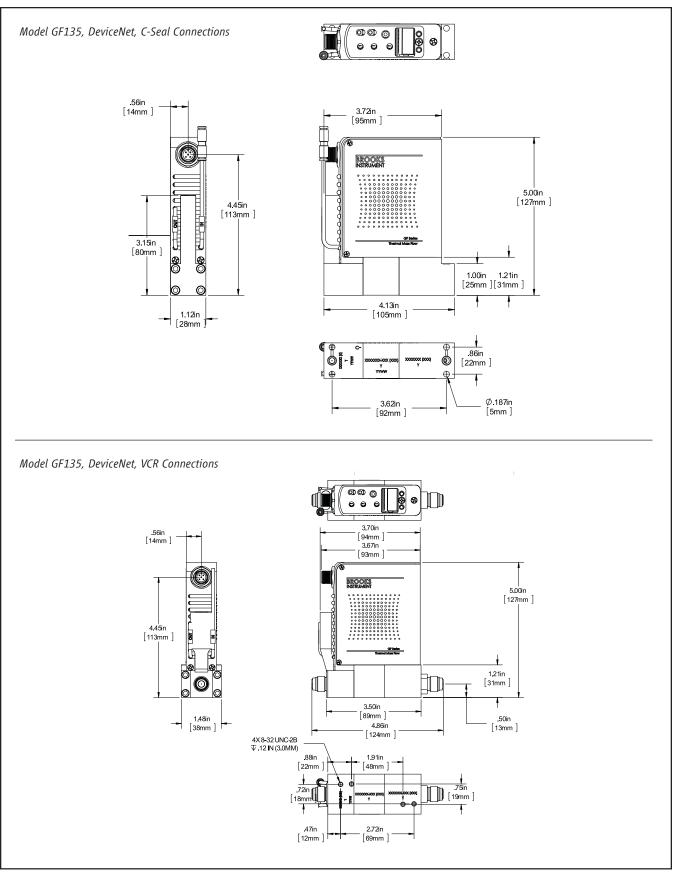
Section 1 Introduction

Performance	GF101	GF121	GF126		
Full Scale Flow Range	61202	55 slm to 300 slm			
Flow Accuracy		<u>+</u> 1% S.P. > 35-100%; <u>+</u> 0.35%	% F.S. 2-35%		
Repeatability & Reproducibility		< <u>±</u> 0.15% S.P.			
Response Time/Settling Time (NC Valve)	< 1 sec				
Pressure Insensitivity		Not Applicable	Ability to measure inlet presssure		
Control Range	5-100% (Normally Closed Valve)				
MultiFlo		Standard			
#of Bins		4 bins			
Valve Shut Down (N.C. Valve)		<2% of F.S. @30 N2 psig/	/atm out		
Zero Stability		< <u>+</u> 0.15% F.S. per y	ear		
Temperature Coefficient		Zero: 0.005% F.S. per	r °C		
atings					
Operating Temperature Range	10-50°C				
Differential Pressure Range	30-90 psid				
Maximum Operating Pressure	Controller: 75 psig Meter: 150 psig				
Leak Integrity (external)	1x10^-10 atm. cc/sec He				
lechanical					
Valve Type	Normally Closed				
Wetted Meterials		Meter (no valve)	1/L Steinlass Steel 204 Steinlass Steel VM 45		
Wetted Materials		ompliant, 316L VIWVAK, Hastelloy C-22, 3	16L Stainless Steel, 304 Stainless Steel, KM-45		
Surface Finish	10µ inch Ra		5µ inch Ra		
iagnostics & Display					
Status Lights		Run, Error, Power, Network			
Alarms	Control Valve Output, Ne		Low, Pressure High/Low, Power Surge/Sag		
Display Type	Top Mount Integrated LCD				
Viewing Angle / Viewing Distance	Rotatable / 10 feet				
Units Displayed / Resolution	Flow (%), Temp. (°C), Pressure (psia, kPa) / 0.1 (unit)				
Electrical					
Electrical Connection		Power via 5-pin M8 Connector,	EtherCAT via RJ45 jacks		
Digital Communication	EtherCAT				
Diagnostic /Service Port		Micro-USB			
Power Supply/Consumption	320 mA max. @ 18-30 Vdc, 230 mA max. @ 24 Vdc (under typical operating conditions)				
Compliance					

Table 1-8 Specifications for GF101/GF121/GF126 Series with EtherCAT Communications

EMC EMC Directive 2014/30/EU Evaluation Standard EN61326-1:2013 Environmental Compliance RoHS Directive (2011/65/EU) REACH Directive EC (1907/2006)





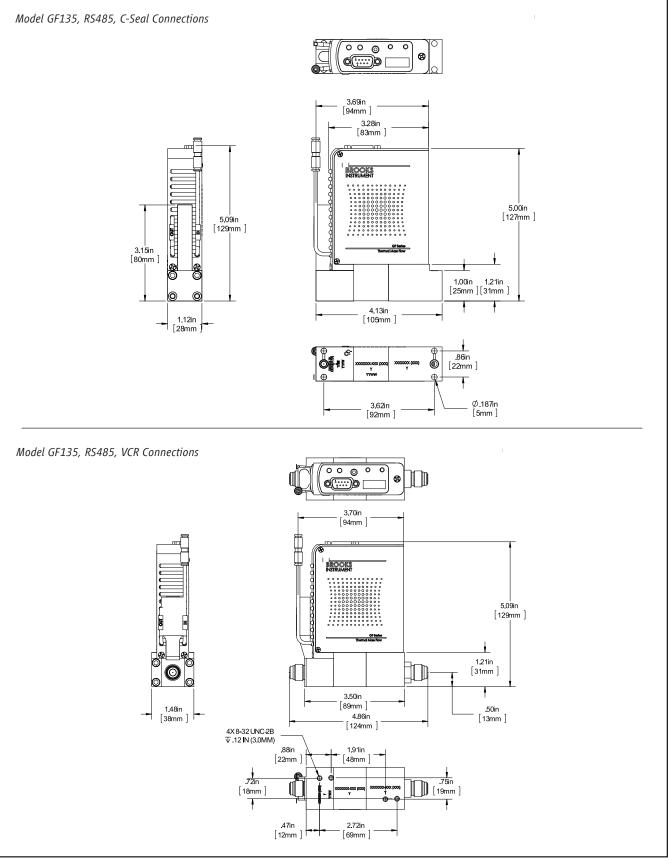
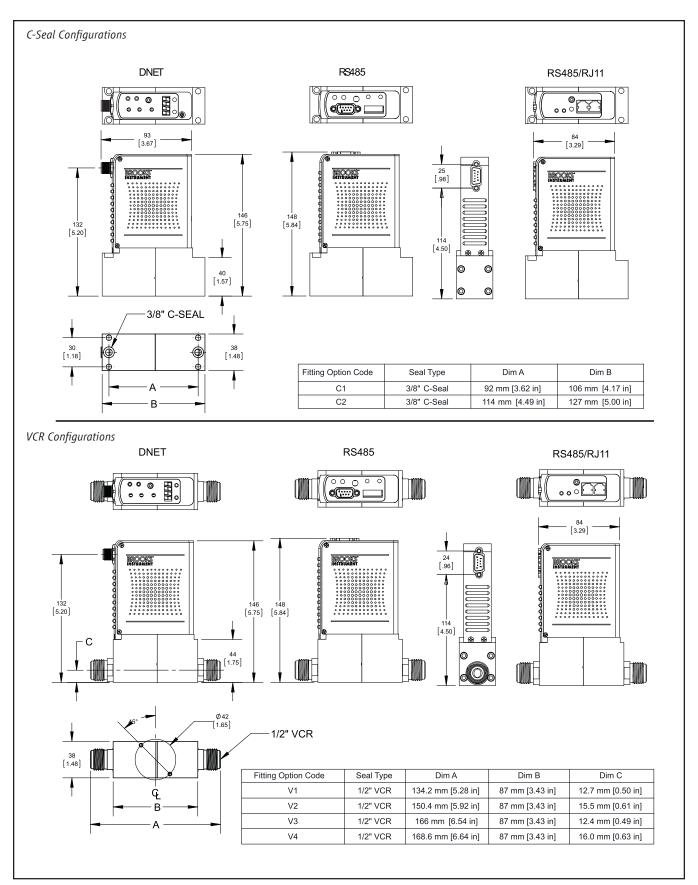


Figure 1-5 Dimensions - GF135 Series, RS485



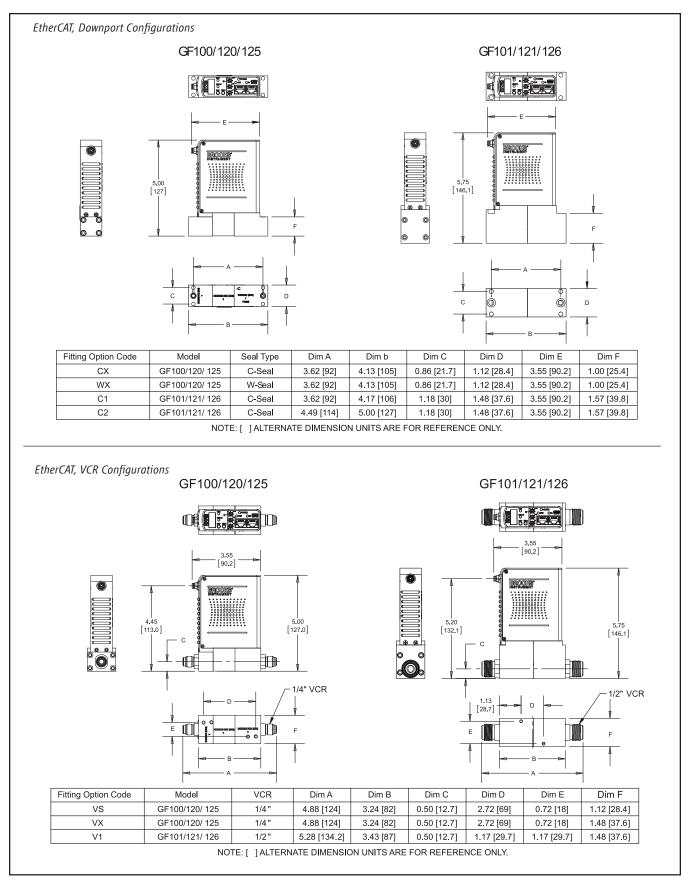


Figure 1-7 Dimensions - GF100/GF120/GF125, GF101/GF121/GF126 Series with EtherCAT Communications

General	
Receipt of Equipment	This section provides installation instructions for the Brooks GF100 Series Thermal Mass Flow Devices. The installation process consists of purging the gas supply line prior to installation, unpacking and inspecting the device, connecting the device to the gas supply line and testing for leaks.
	When the equipment is received, the outside packing case should be checked for damage incurred during shipment. If the packing case is damaged, the local carrier should be notified at once regarding his liability. A report should be submitted to the nearest Brooks Instrument location listed on the Global Service Network page on our website: BrooksInstrument.com/GlobalSupportCenters This device has been assembled, calibrated, and double-vacuum bagged in a Class 100 clean room. In your semi-clean area, remove the outer bag only. Pass the device into your clean area. Remove the second clean room compatible bag only when the device is ready to be tested and/or installed in your clean system.
Recommended Storage Practice	
	 If intermediate or long-term storage of the device is required, it is recommended that it be stored in accordance with the following conditions: Within the original shipping container. Ambient temperature 21°C (70°F) nominal, 32°C (90°F) maximum, 7°C (45°F) minimum. Relative humidity 45% nominal, 60% maximum, 25% minimum.
Return Shipment	
	Prior to returning any instrument to the factory for any reason, visit our website for instructions on how to obtain a Return Materials Authorization Number (RMA #) and complete a Decontamination Statement to accompany it: BrooksInstrument.com/Service. All instruments returned to Brooks also require a Material Safety Data Sheet (MSDS) for the fluid(s) used in the instrument. Failure to provide this information will delay processing of the instrument. Instrument must have been purged in accordance with the following:
	AWARNING Before returning the device, purge thoroughly with a dry inert gas such as Nitrogen before disconnecting process connections. Failure to correctly purge the instrument could result in fire, explosion or death. Corrosion or contamination may occur upon exposure to air.

Section 2 Installation

Transit Precautions	
	To safeguard against damage during transit, transport the device to the installation site in the same container used for transportation from the factory, if circumstances permit.
Removal from Storage	
	Upon removal of the device from storage, a visual inspection should be conducted to verify its "as-received" condition. If the device has been subject to storage conditions in excess of those recommended (refer to "2-3 Recommended Storage Practice" on p. 2-1), it should be subjected to a pneumatic pressure test in accordance with applicable vessel codes. To maintain a devices ultraclean integrity, this service should be performed by the factory or one of the certified service centers.
Gas Connections	
	Prior to installation, ensure that all piping is clean and free from obstructions. Install piping in such a manner that permits easy access to the device if removal becomes necessary.
In-Line Filter	
	It is recommended that an in-line filter be installed upstream from the device to prevent the possibility of any foreign material entering the flow sensor or control valve. The filtering element should be replaced periodically or ultrasonically cleaned.
Mechanical Installation	
	When installing the Mass Flow Controller or Meter, care should be taken that no foreign materials enter the inlet or outlet of the instrument. Do not remove the protective end caps until the time of installation.
	 The recommended installation procedure guidelines are as follows: The device should be located in a clean, dry atmosphere relatively free from shock and vibration. Leave sufficient room for access to the user interface, display and MAC ID and baud rate switches (if equipped) at the top of the device. Install the device in such a manner that permits easy purge and removal if the device requires servicing.
	ΛΟΛΗΤΙΟΝ

When used with a reactive (sometimes toxic) gas, contamination or corrosion may occur as a result of plumbing leaks or improper purging. Plumbing should be checked carefully for leaks and the instrument purged with clean, dry N_2 before use.

The GF100 Series is equipped with PTI technology, which reduces the effect of pressure fluctuations on gas flow. In PTI technology, a signal from an integrated pressure transducer is combined with the standard thermal sensor output. The combined signals allow precise and stable flow, even when the line pressure is fluctuating.

The GF100 Series also utilizes MultiFlo[®] technology that allows the user to configure standard configurations ("SHs") or "blanks" for a variety of pure gases and mixtures. As a result, MultiFlo[®] technology enables the user to reduce unique inventory requirements.

Flow Controller Installation Arrangement

Typical gas supply arrangements are shown in Figures 2-1 and 2-2. GF100's are often arranged inside a gas panel. Configure standard configurations ("SHs") or "blanks" for a variety of pure gases and mixtures. As a result, MultiFlo technology enables the user to reduce unique inventory requirements.

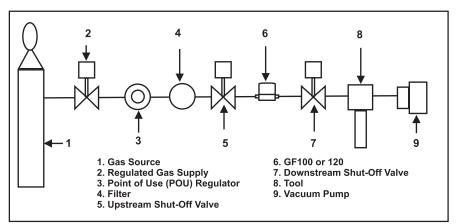


Figure 2-1 Typical Gas Supply Arrangement with non-PTI MFC

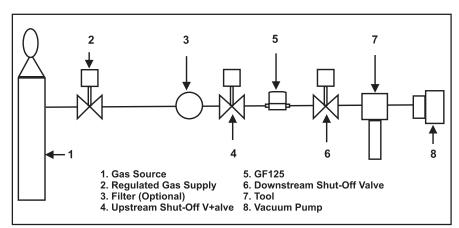


Figure 2-2 Typical Gas Supply Arrangement with PTI MFC

Purge the Gas Supply Line Before GF100 Series Installation

For additional safety, it is recommended to close the two valves between the charged gas line and the GF100 Series to be installed. See Figures 2-1 and 2-2 for more details.

It is recommended to archive service and calibration documentation for the GF100 Series in order to determine the contamination state of each gas line and to assist service personnel.

DO NOT remove the shipping caps covering the inlet/outlet for VCR fittings, or DO NOT remove the blue tape on the bottom of the device for downported fittings before the GF100 Series is actually being installed. Failure to comply will introduce contaminants into the GF100 Series.

Before operating the GF100 Series, the gas supply line must be completely purged with nitrogen or argon to ensure the line is free from toxic or flammable gases, contaminants, moisture, and oxygen. The purge gas must be free of moisture and oxygen to less than 100 ppb. Purge the gas lines as follows or in accordance to prescribed company and safety procedures.

- 1. Shut off the process gas supply valve(s) upstream of the GF100 Series. If such a valve is not available, shut the valve on the gas panel. Tag the valve at this point to prevent accidental re-exposure of the process gas to the gas line.
- 2. Cycle purge the gas line with dry nitrogen or argon to fully flush out the process gas. Cycle purging consists of evacuating to a low pressure adequate to induce out-gassing and then purging to remove adhered moisture and oxygen. If a toxic or reactive gas is present and a clogged GF100 Series is suspected, then proceed with caution. Pump down and purge the GF100 Series from both downstream and upstream lines. If check valves are present in the gas line, both pumping down and purging are required. Pumping down without purging is inadequate. If a good vacuum source is not available, the GF100 Series can be decontaminated by purge only.
- 3. Repeat the purge cycle several times within 2-4 hours to complete the cleaning. For toxic and corrosive gasses, it is recommended to use 100-120 cycles.

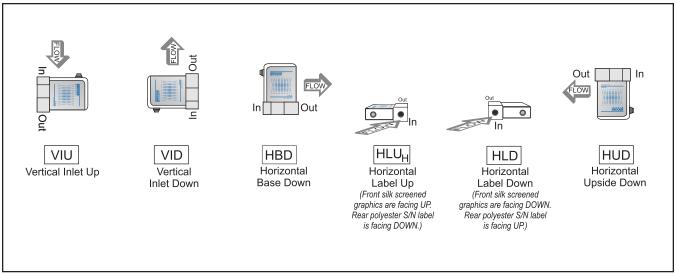


Figure 2-3 GF100 Series Mounting Attitude Positions

Position and Mount the GF100 Series

Position the GF100 Series so that the gas flow is pointed in the direction of the flow arrow on the GF100 Series rear S/N label. The various mounting positions are described in Figure 2-3

The standard orientation for the GF100 Series is Horizontal Base Down (HBD). The GF125 & GF135 employ a proprietary algorithm that utilizes the internal pressure sensor to compensate for potential orientation effects when the MFC is used with certain higher density gases. Non HBD mounting orientations can be selected by using the MultiFlo software.

In the case of the GF100/120 Series, which does not have an internal pressure sensor, it is recommended that the MFC is re-zeroed with process gas following the recommended Brooks procedure (see zeroing bulletin FSB-001-0015 for further information).

If your GF100 Series is configured with downported fittings, follow Steps 1 though 4 below. If your GF100 Series has VCR fittings, proceed to Step 5.

- Refer to Figure 2-4. If downported fittings (1) are used, the GF100 Series is mounted to K1 Series substrate blocks (2) with four screws (3). Metal C-seals or W-seals (4) (as provided by integrator) are inserted between the GF100 Series and substrate blocks before the screws are installed. These metal seals must be replaced after each installation.
- Select the mounting screws noted in Table 2-1 below for downported devices. M4 screws are used on 1.125" devices, K1S. M5 screws are used on 1.5" devices, K1R2 and K1H.
- Refer to Figure 2-4. Insert the two mounting seals (4) over the gas flow path of the K1 block. Carefully align the GF100 Series mounting holes onto the K1 substrate blocks. Using your fingers, install the screws through the GF100 Series fitting and hand tighten.

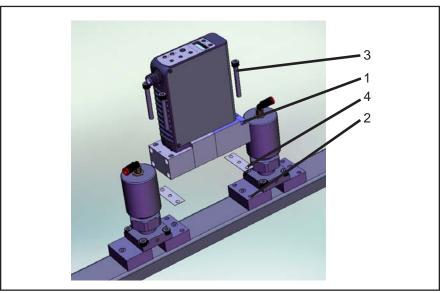


Figure 2-4 GF100 Series Mounted to K1 Series Substrate Blocks

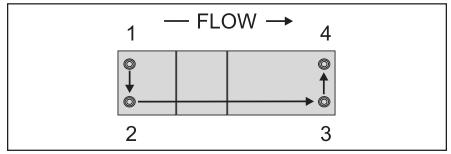


Figure 2-5 Mounting Screws Torque Pattern*

Table 2-1 K1 Series Fasteners*

Connection	Fastener Size				
	K1S	K1R2	K1H		
GF 100 Series	M4 x 34mm	M5 x 30mm	M5 x 37mm		
to	or				
Subtstrate	M4 x 35mm				

Table 2-2	K1	Substrate	Torque	Data*
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Connection	Torque Pattern	Torque (I	nch-Pound	s)
GF125 to	Use a square pattern as	K1S	K1R2	K1H
Subtstrate	shown in Figure 2-5. Start at 25 inch-pounds and increase in increments of 10 inch-pounds until proper value is obtained.	45	45	45

- 4. Using a torque wrench and a metric hex key, tighten the screws to the torque value as described in Table 2-2 and Torque Pattern Figure 2-5.
- 5. If your GF100 Series is configured with ¼" VCR fittings, secure the GF100 Series block to the gas panel with two, 8-32-UNC-2B" screws. Then connect the inlet/ outlet fittings to the gas supply line using two wrenches. Tighten the fittings to manufacturer recommendations.

*Torquing methodology is the responsibility of the tool manufacturer

Perform a Leak Test

	AWARNING		
	Before operating the flow controller, ensure all gas connections have been properly tightened and, where applicable, all electrical connections have been properly terminated.		
	It is critical to leak test the gas supply lines and GF100 Series connections before turning on the process gas supply after any new installation. Check for leaks using a helium leak detector or any other appropriate leak test method. Follow leak test specifications as defined by integrator.		
oing Setup Process			
	The following steps are required before the GF100 Series is zeroed.		
	 Make sure that the GF100 Series has been installed inside the equipment (panel) for at least four hours and powered up at least one hour prior to zeroing. This insures that the GF100 Series is in its "use attitude" and is operating at normal temperature. If the GF100 Series is subjected to a vacuum purge for more than one minute, turn off the GF100 Series (ie., provide a zero setpoint) for a time period of twice the vacuum purge time. 		
	2. Refer to Figure 2-1. Open the upstream shut-off valve (5) and close the downstream shut-off valve (7). This eliminates a pressure drop across the GF100 Series and subsequent leakage from the PID control valve inside the GF100 Series.		
	Provide a 100% setpoint to the GF100 Series for no longer than 60 seconds. This equalizes the pressure across the PID control valve.		
	 Refer to Figure 2-1. Close the upstream shut-off valve (5) to prevent any pressure effects from the regulator (3). 		
	5. Close the GF100 Series and wait two minutes.		
	 Read the output signal of the GF100 Series. This output signal is the initial flow in percent of full scale. The output signal should be 0.0 (± 0.1%). If the output signal is too high, re-zero the GF100 Series as described in Section 2-15. 		
ng the GF100 Series			
	Many high density gases exhibit slight changes in zero output as a function of inlet pressure. Gases such as tungsten hexafluoride and many fluorocarbons are especially sensitive to this problem. Since inlet pressure is a potential source for zero errors, the pressure transducer on each GF100 Series should be correctly set to zero after installation. The zeroing process is performed from the backlight LCD display on top of the GF100 Series.		
	OEM tools using a microprocessor or computer for operating the GF100		

OEM tools using a microprocessor or computer for operating the GF100 Series should sequence the GF100 Series off between processes. To accomplish this, simply provide a zero set point. The GF100 Series will shut off automatically.

Make sure you perform the zeroing set-up process outlined in Section 2-14 before zeroing the GF100 Series.

Shut-off valves, whether upstream or downstream from the GF100 Series, should be programmed to turn on before the GF100 Series is turned on and turned off after the GF100 Series is turned off.

Zeroing the GF100 Series Pressure Transducer from the LCD Display Panel

- 1. Place the GF100 Series under a strong vacuum with the GF100 Series set to 100% set point. Make sure that upstream valve is closed and the downstream valve is open. Allow time for the upstream pressure to bleed off.
- 2. Looking at the top of the GF100 Series, press the "Display" button, starting at the MACID, four times to "PSI" or five times to "kPa" or until the LCD displays the labels "PSI" or "kPa". The GF100 Series will display pressure in units of PSIA or kPa. Press and hold down the Zero button a minimum of 5 seconds or until the display reads 0.000, with the last two digits flickering at different values. The pressure transducer zeroing procedure can be done while the display is either in PSIA or kPA output. Refer to Figure 2-6.



Figure 2-6 Display with PSI Reading

After completion of the pressure transducer zeroing, the LCD display will read 0.0 with the last two digits flickering as shown in Figure 2-7.



Figure 2-7 Display Reading Zero PSI

Zeroing GF100 Series Flow from LCD Display Panel

- 1. Place the GF100 Series under normal inlet operating pressure. Close the down stream valve to prevent any flow.
- 2. Looking at the top of the GF100 Series, press the "Display" button until the LCD display label is "%FS" as shown in Figure 2-8. Three button depressions from the MACID label display.



Figure 2-8 Display Set to %FS

3. Press and hold down the Zero button for a minimum of 5 seconds or until the "%FS" display reads 0.0 as shown in Figure 2-9. The %FS label will flash during this procedure.

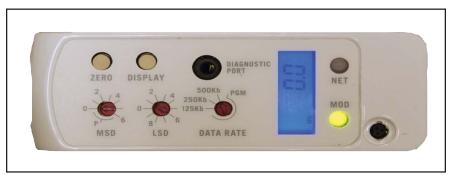


Figure 2-9 % Flow Display Set to Zero

Performance Checks

This section describes how to zero and sequence the GF100 Series devices for proper operation.

ANOTICE

If the GF100 Series has been in the purge mode for a long period of time, wait until the GF100 Series has cooled down before zeroing. The cool down period should be ~30 minutes for purges up to five minutes and at least 60 minutes after purging overnight.

- The GF100 Series must be warmed up for at least 30 minutes.
- The active gas page must be correct.
- The GF100 Series pressure transducer must be correctly zeroed.
- The GF100 Series flow must be correctly zeroed.

Introduction to the MultiFlo[™] Configurator

The MutliFlo Configurator application is used to configure the gas and range of the GF Series devices. The following section describes the MultiFlo Configurator and its uses.

Using the MultiFlo Configurator

The MultiFlo Configurator application allows communication to GF Series devices through personal computer with serial COM Port and a Windows 10, Windows 7 or Windows XP operating system. It's primary function is to configure gas and flow ranges within six defined standard configurations. Flow ranges are configured to the Nitrogen equivalent.

Using the MultiFlo Configurator software, configure the gas and flow rate according to Table 2-3.

Standard MG-MR Bin	Flow range	Gas Flow Range
Configurations	Code	(N2 Equivalent)
SH40	010C	3-10 sccm
SH41	030C	11-30 sccm
SH42	092C	31-92 sccm
SH43	280C	93-280 sccm
SH44	860C	281-860 sccm
SH45	2.6L	861-2600 sccm
SH46	7.2L	2601-7200 sccm
SH47	015L	7201-15000 sccm
SH48	030L	15001-30000 sccm
SH49	040L	30001-40000 sccm
SH50	055	40001-55000 sccm

Table 2-3 Gas and Flow Ranges - MultiFlo Configurable - N2 Equivalent

The MultiFlo Configurator interfaces to the GF Series device through RS485 or DeviceNet communications. There are various ways to connect the device regardless of device configuration. Devices may be connected through the diagnostic port using cables in one of the two Basic MultiFlo Configurator Kits or DeviceNet devices can alternatively be connected using a National Instruments or SST DeviceNet scanner card.

778Z010ZZZ Basic MultiFlo Configurator Kit

A331710003 Cable Assembly 2.5mm 214F027AAA USB-RS485 Converter with DB-9 female

778Z011ZZZ Basic MultiFlo Configurator Kit

w/Power Supply and Adapter Cables A331710003 Cable Assembly 2.5mm 214F027AAA USB-RS485 Converter with DB-9 female A332295001 Power Supply MFC A332297002 Cable, Power, 9-Pin A332297001 Cable, Power, DeviceNet

Connect the MultiFlo Cable Adapter 2.5mm jack to the Diagnostic Port on the top of the device. See Figure 2-12.

Connect the RS485 end of the converter to the 9-Pin RS485 end of the MultiFlo Cable Adapter.

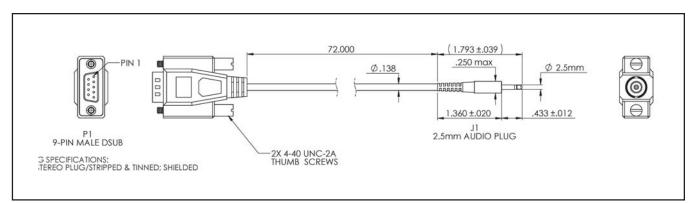


Figure 2-10 MultiFlo Cable Adapter



Figure 2-11 USB-RS485 Converter (214F027AAA)

Connect the USB end of the converter to a laptop or PC. For GF1xx devices with EtherCAT communication, the diagnostic port must be used to interface with the MultiFlo Configurator.

- Ensure the M8 power connector is attached and the device is powered on
- Only after the device is powered on, attach a micro-USB cable to the diagnostic port of the device and the USB end to a laptop or PC

• Once use of the diagnostic port is complete, remove the micro-USB cable before removing power from the device. See Figure 2-12 below



Figure 2-12 Diagnostic Port Locations

The latest MutliFlo Configurator Software and Databases and MultiFlo Configurator Quick Start Guide are available on the Brooks Instrument website at: <u>www.BrooksInstrument.com/MultiFlo</u>. Please reference the MultiFlo Configurator Quick Start Guide for installation and operation details. Download the MultiFlo Configurator software into your computer from the Brooks Instrument website <u>www.BrooksInstrument.com/MultiFlo</u>. Install the MultiFlo Configurator as described in the MultiFlo Configurator Quick Start Guide and use the guide as a reference for operation details.

A CAUTION

DO NOT make any connections to unlabeled connector pins. Any failure to comply could damage the GF100 Series and/or the mating electrical device. Before connecting the cable, make sure that all pin connections of the mating cable have the same pin out connections. When installing and removing cables to and from your computer, make sure the power is turned off on your computer. This will prevent damage to your computer and associated equipment.

Electrical Connections

DeviceNet Connections

DeviceNet is a 5 wire local network connection that employs a command response communication protocol for communicating between a master and slave. Obtain a DeviceNet communication cable (Micro M-12) and fasten it to the 5-pin connector as shown in Figure 2-13.

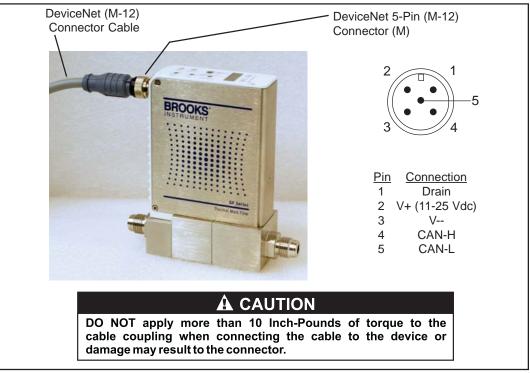


Figure 2-13 GF100 Series DeviceNet Connection

Analog/RS485 Connections

Analog 9-Pin Connector (Refer to Figure 2-15 for Pin-Out Details)

The GF100 Series devices are available with Analog 9-Pin D-Connectors shown in Figure 2-14.

Figure 2-14 GF100 Series with 9-Pin Analog Connector

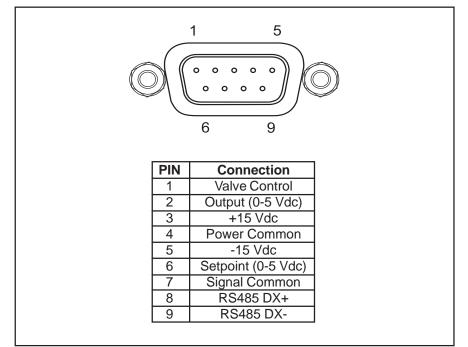


Figure 2-15 Analog 9-Pin Connector (M)

EtherCAT Connections

Power needs to be supplied via the standard male M8 5-pin connector. The M8 connector is located on the upper inlet side of the device. Refer to Figures 2-16 and 2-17 below.

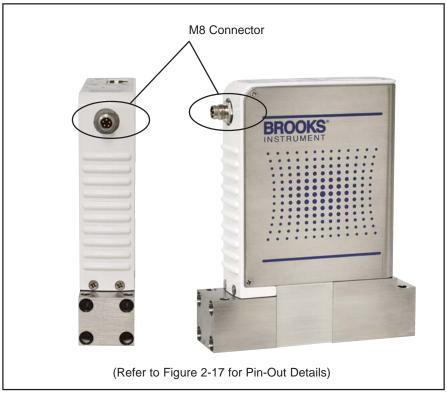


Figure 2-16 GF100 with EtherCAT Communications, M8 Power Connector Location.

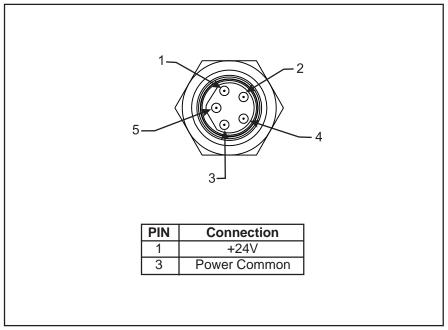


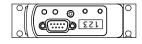
Figure 2-17 M8 Power Connector Drawing

Base I/O Options

PDC Ordering Code G1 Description: Industry standard Analog / RS485 interface

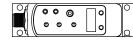


PDC Ordering Code GX Description: OEM specific Analog / RS485 interface. Display and top plate re-oriented 180°

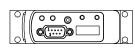


PDC Ordering Code DX

Description: Industry standard ODVA compliant DeviceNet interface

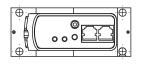


PDC Ordering Code TX Description: Industry standard Analog only interface



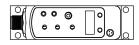
PDC Ordering Code SX

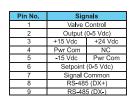
Description: Industry standard Analog 9-Pin Sub D connector and dual R]11 RS485 ports

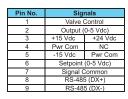


PDC Ordering Code BB

Description: Industry standard ODVA compliant DeviceNet interface, Plus a separate Analog 0-5 Vdc Connector







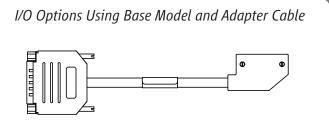


Pin No.	Signals	
1	Valve (Control
2	Output (0-5 Vdc)
3	+15 Vdc	+24 Vdc
4	Pwr Com	NC
5	-15 Vdc	Pwr Com
6	Setpoint	(0-5 Vdc)
7		Common
8	No Cor	nection
9	No Cor	nnection

D-Sub Pin No.	Sig	nals
1	Valve Control	
2	Output (0-5 Vdc)
3	+15 Vdc	+24 Vdc
4	Pwr Com	NC
5	-15 Vdc	Pwr Com
6	Setpoint (0-5 Vdc)	
7	Signal Common	
8	Signal Common	
9	Valve Te	est Point
RJ11 J2 Pin No.	Signals	
3	RS-48	5 (DX-)
4	RS-48	5 (DX+)

M12 Pin No.	Signals
1	Drain
2	V+ (11-25 Vdc)
3	V-
4	CAN-H
5	CAN-L
HIROSE Pin No.	Signals
1	Flow Out
2	AGND
3	GPIO CAP0
4	GHD Earth

All Base I/O options include: Diagnostic port communication RS485 via 2.5mm jack



A range of low profile adapter cables have been developed to support replacing older generation MFC's with different pinout configurations. The base MFC will be either a G1, TX or SX configuration, depending on the product being replaced.

PDC Ordering Code UX

Description: SX base I/O with 7003550 adapter for compatibility with Unit UDU15

Pin No	S	ignals
9	VALVE OFF	
6	OUTPU	IT (0-5 VDC)
4	+15 VDC	+24 VDC
7	PWR COM	NC
11	-15 VDC	PWR COM
15	SETPOINT (0-5 VDC)	
1,13,14	SIGNAL COMMON	
2	ZERO ALARM	
12	VALVE TEST POINT	
8	CASE GROUND	
3.5.10	NO CC	NNECTION

PDC Ordering Code: FX / JX Description: SX base I/O with 7003069 (FX)/7001814 (JX) adapter for compatibility with Unit UDF9/UDJ9

Pin No	Sig	nals
1	VALVE CONTROL*	
2	OUTPUT	(0-5 VDC)
3	+15 VDC	+24 VDC
4	PWR COM	NC
5	-15 VDC	PWR COM
6	SETPOINT (0-5 VDC)	
7	SIGNAL	COMMON
8	SIGNAL	COMMON
9	VALVE TE	ST POINT

PDC Ordering Code: KX

Description: G1 base I/O with 7003298 adapter for compatibility with Unit UDK15

Pin No	Sigr	nals
3	VALVE CONTROL	
2	OUTPUT (0-5 VDC)
7	+15 VDC	+24 VDC
5	PWR COM	NC
6	-15 VDC	PWR COM
8	SETPOINT (0-5 VDC)
11,12	SIGNAL C	OMMON
15	CASE GI	ROUND
1, 4, 9, 10,	NO	
13, 14	CONNE	CTION

PDC Ordering Code: T1 Description: TX base I/O with 7003551 adapter for compatibility with IFlow DB15 & TN 15 pin

Pin No	Sig	nals
15	VALVE OFF	
2	OUTPUT (0-5 Vdc)	
5	+15 VDC	+24 VDC
1	PWR COM	NC
6	-15 VDC	PWR COM
8	SETPOINT (0-5 VDC)	
9	CON	IMON
10	CON	1MON
14	CASE 0	GROUND
3,4,7	NO CON	NECTION
11,12,13	NO CON	NECTION

PDC Ordering Code: EX

Description: GX base I/O with 7003083 adapter for compatibility with Unit "E", IN "L", "R"

Pin No		Sig	nals
J		VALVE	E OFF
3	(DUTPUT	(0-5 VDC)
4	+15 \	/DC	+24 VDC
2	PWR	СОМ	NC
F	-15 \	/DC	PWR COM
А	SI	ETPOINT	(0-5 VDC)
B,C,10	SIGNAL COMMON		
1		CASE G	ROUND
5, 6, 8, 9	NOT CONNECTED		
I, D, E, H		NOT COM	NECTED
7,G		KEY	WAY
RJ11 J2 Pin No	RJ11 J3 Pin No		
3	3	RS-485	(DX-)
4	4	RS-485	(DX+)

PDC Ordering Code: BX

Description: G1 base I/O with 7003590 adapter for compatibility with Brooks 15-Pin D

Pin No	Sig	nals
12	VALVE OVERRIDE	
2	OUTPUT (0-5 VDC)
5	+15 VDC	+24 VDC
9	PWR COM	NC
6	-15 VDC	PWR COM
8	SETPOINT (0-5 VDC)
1,10	SIGNAL COMMON	
3,4,7,11	NO CONNECTION	
13,14,15	NO CONN	IECTION

Other adapter options are available for the GF Series. Please contact Brooks Customer Service for more information.

GF135 Inlet Valve Installation

When installing the GF135 -

1. Connect the MFC tubing labeled "IN" to a CDA or N2 supply of 90 ±3 psi.

2. Next, the MFC tubing labeled "OUT" should be connected to the customer upstream pneumatic isolation valve.

Note – The air passes through a failsafe normally open valve inside the GF135 and is connected back to the inlet isolation valve. For safe operation and in line with S2 compliance, the GF135 cannot override and open the inlet isolation valve.

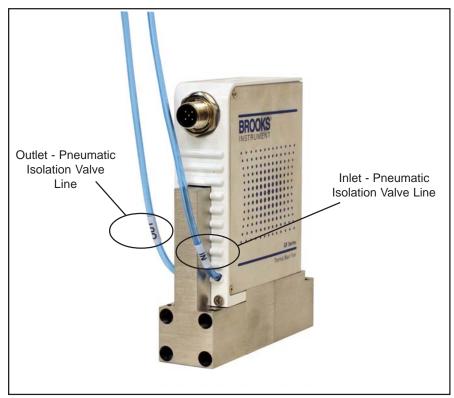


Figure 2-19 GF135 Series Showing Inlet/Outlet Pneumatic Isolation Valve Lines

GF135 Commissioning

Download the GF135 commissioning software, part number 805-C-026, from the Brooks Instrument website. The software will need to be downloaded onto a computer with a Windows[®] based operating system.

Necessary equipment:

- Computer that runs a Windows operating system
- Power (either DeviceNet or RS485) to the device or M8 EtherCAT power
- Need gas supply for pneumatic valve (90 ±3 psi)
- BB 485 to 232 converter or approved USB to 485 converter
- 9-pin to diagnostic cable

In order to ensure best results, commission the GF135 at operating temperature and pressure on tool.

BROOKS	GF135Commission (1.0.0)	
Commission	Commission	
🌒 Exit	Communications Port Connect To Device Control/Sense MAC IDs GF1 MAC 32 Commission	
	Device Gas	
	All MAC's located - select device and connect to it.	

1. Start up the GF135 Commission Application and select a port. This will bring up all of the devices on this port.

BROOKS	GF135Commission (1.0.0)	
Commission	Commission	
🛃 Exit	Connect To Port COM7 Connect To Device	
	Control/Sense MAC IDs GF1 MAC 32 Commission	
	Device Gas CH3F	
	Device ready for Commissioning	
	ii.	

2. Select the single device that you want to perform the commissioning and click on "Connect to Device". The Commissioning button becomes enabled.

BROOKS	GF135Commission (1.0.0)
Commission	Commission
Exit	Communications Port COM7 Connect To Device
	Control/Sense MAC IDs GF1 MAC 32 Commission
	Device Gas CHUF Terminate
	GF135 Port: COM7, Baud Rate: 115200

3. Click on the "Commission" button to begin the process. Some intermediate messages will appear on the bottom mesage bar. You will then be presented the option to override the current inlet gas pressure. Selecting "Yes" will keep the current inlet pressure. Selecting "No" will allow the user to override the pressure. Selecting "Cancel" will end the commissioning process.

BROOKS	GF135Commission (1.0.0)
Commission	Commission
🚽 Exit	Communications Port COM7 Connect To Device
	Control/Sense MAC IDs GF1MAC 32
	Device Gas CH3F Terminate
	Checking for Leak check Override GF135 Port: COM7, Baud Rate: 115200
	Warning. The leakage is out of range for this device. Expected to be less than 0.022 value is 0.050 Would you like to continue anyway?
	Yes No

4. The user will be presented the option to override a few of the parameters being tested prior to actual commissioning. Selecting "Yes" will continue the process. By selecting "No" the commissioning process will end.

BROOKS	GF135Commission (1.0.0)	
Commission	Commission	
🚽 Exit	Communications Port COM7 Convect To Device Control/Sense MAC IDs Commission GF1MAC 32 Commission	
	Device Gas Ortige Terminate Starting Auto-volume commissioning	

5. After numerous checks are performed, the auto-volume will start. This will take approximately 5 minutes to complete. The K1 setpoints will then begin. This process will run for approximately 40-90 minutes.

GF135Commission (1.0.0)	
Commission	
Communications Port Select a port Connect To Device	
Control/Sense MAC IDs GF1 MAC	
Device Gas Terminate Commissioning Completed in 36.45 minutes.	
	Commission Communications Port Select a port Control/Sense MAC IDs GF1 MAC Device Gas Terminate Commissioning Completed in 36.45 minutes.

6. Once the auto-volume and the K1 set points are complete, the program will go back to the initial screen. In addition, the overall run time will be displayed. From here, another device (or the same one again) may be selected for commissioning.

General

After the device has been properly installed in the process, it is ready for operation. When initiating flow, slowly open any upstream shutoff valve to avoid a flow surge. A bypass is helpful in bringing the flow on smoothly. Avoid starting a pump to supply the device without the use of a valve upstream of the device.

A CAUTION

Any sudden change in system pressure may cause mechanical damage to elastomer materials. Damage can occur when there is a rapid expansion of fluid that has permeated elastomer materials. The user must take the necessary precautions to avoid such conditions.

AWARNING

Before operating the flow controller, ensure all gas connections have been properly tightened and, where applicable, all electrical connections have been properly terminated.

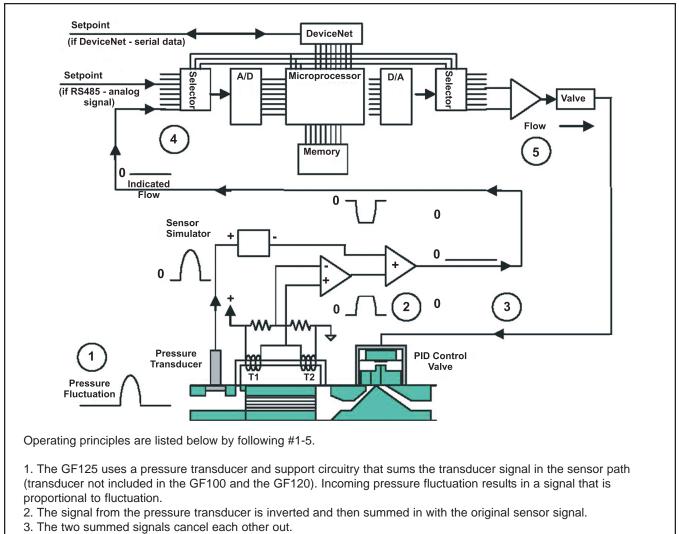
Theory of Operation for Flow Measurement

The thermal mass flow measurement system consists of two components: the restrictor or bypass and the flow sensor. Figure 3-1 is diagram of the flow stream through the device, with an enlarged view of the flow sensor. Gas flow entering the device is separated into two paths; one straight through the restrictor and the other through the flow sensor. This is represented in Figure 3-1, where the total flow A+B enters the device and is separated into streams A and B. The streams are joined again at the far side of the restrictor.

The separation of the flow streams is caused by the restrictor. During flow conditions, there will be a pressure differential across the restrictor that forces gas to flow in the sensor.

The pressure difference caused by the restrictor varies linearly with total flow rate. The sensor has the same linear pressure difference versus flow relationship. The ratio of sensor flow to the flow through the restrictor remains constant over the range of the device (A/B = constant). The full scale flow rate of the device is established by selecting a restrictor with the correct pressure differential for the desired flow.

The flow sensor is a very narrow, thin-walled Hastelloy tube. Onto this tube are built upstream and downstream temperature sensing and heating elements. During no-flow conditions, the amount of heat reaching each temperature sensor is equal, so temperatures T1 and T2 (Figure 3-1) are equal. Gas flowing through the tube carries heat away from the upstream temperature sensor and toward the downstream sensor. The temperature difference, T2 - T1, is directly proportional to the gas mass flow. GF100 Series operating principles are described in Figure 3-1.



- 4. The sensor signal that is applied to the microprocessor is undisturbed.
- 5. The flow of process gas is undisturbed by incoming pressure fluctuations.

Figure 3-1 GF100 Series Operating Principles

Overview

No routine maintenance is required on the Brooks GF100 Series devices. If an in-line filter is used, the filtering elements should be periodically replaced or cleaned. Any precision unit such as a flow controller requires occasional servicing, especially if it has been operating for an extended period of time. If reactive gases are being used, it is recommended that you send the device to a Brooks Service Center for cleaning and recalibration. Please follow the instructions for removal, product packaging and product return instructions found in Section 2- Installation—Return Shipment. All active process instrumentation and equipment is subject to aging and wear from their environment. This includes temperature, mechanical stress, component tolerance shift, contaminant buildup, oxidation, and other influences. The effects are gradual, but over time the changes can affect the accuracy of even the best equipment. Therefore, it is recommended to re-zero the device at 6 month intervals. Refer to Section 2-18 Performance Checks for re-zeroing instructions.

Maintenance



Products in this manual may contain metal or elastomeric seals, gaskets, O-rings or valve seats. It is the "user's" responsibility to select materials that are compatible with their process and process conditions. Using materials that are not compatible with the process or process conditions could result in the Meter or Controller leaking process fluid outside the pressure boundary of the device, resulting in personnel injury or death.

It is recommended that the user check the Meter or Controller on a regular schedule to ensure that it is leak free as both metal and elastomeric seals, gaskets, O-rings and valve seats may change with age, exposure to process fluid, temperature, and /or pressure.

If it becomes necessary to remove the controller from the system after exposure to toxic, pyrophoric, flammable or corrosive gas, purge the controller thoroughly with a dry inert gas such as Nitrogen before disconnection the gas connections. Failure to correctly purge the controller could result in fire, explosion or death. Corrosion or contamination of the mass flow controller, upon exposure to air, may also occur.

If it becomes necessary to remove the instrument from the system, power to the device must be disconnected.

It is important that this MFC/MFM only be serviced by properly trained and qualified personnel.

This instrument contains electronic components that are susceptible to damage by static electricity. Proper handling procedures must be observed during the removal, installation or other handling of internal circuit boards or devices.

Troubleshooting

This section includes a Troubleshooting Checklist and a GF100 Series Troubleshooting Guide that identifies symptoms, possible causes, and corrective actions.

OEM tool problems are often caused by something other than the GF100 Series. Therefore, Brooks recommends that you review both the Troubleshooting Checklist and the GF100 Series Troubleshooting Guide before removing the GF100 Series from your system. It is also suggested to contact your Brooks Service representative before removing the GF100 Series from your system.

Troubleshooting Checklist

1. Check environmental factors that could affect changes to GF100 Series performance. The most common environmental factors are listed in Table 4-1.

Table 4-1 Environmental Factors

GF100 Series Performance	Possible Causes
Inaccurate flow.	Temperature shift (steady state or transient). Inlet pressure shift (steady state or transient). Power supply problem. Electrical interference Dirty gas chamber Changes in gas.
Control problems. Can not reach setpoint. Oscillation.	Differential pressure not within operating range Inlet pressure not stable
Zeroing problems, Indicated zero is not stable.	Temperature shift (steady state or transient). Inlet pressure shift (steady state or transient). Power supply problem. Electrical interference

- 2. Check supply voltage and check for a consistent ground.
- 3. Insure OEM tool setpoint matches the setpoint at the GF100 Series. Observe for consistency.
- 4. Verify isolations valves are open and the gas supply is turned on. Then verify operating pressures are within operating ranges.
- 5. Check GF100 Series voltage response by moving the setpoint back and forth.

Observe for voltage changes.

GF100 Series Troubleshooting Guide

Table 4-2 GF100 Series Troubleshooting Guide

Symptoms & Possible Causes	Corrective Action
1. No gas flow.	
Is the gas supply turned on?	Check shut-off valve and pressure readout. Open
	the gas supply.
Is the regulator turned on at the	Turn off the regulator and reset it to the
correct operating pressure?	recommended pressure as described in the
	Data Sheet.
Are any upstream or downstream	Verify that the valves are open and operating
shut-off valves closed, either by	properly.
the system or because of failure?	
Is the MOD LED light on the GF100 Series	Observe the LED display panel on top of to
lit solid green?	verify. If the LED light is not lit, cycle power the
C C	to reboot.
Is the commanded setpoint from	Use the tool software to verify.
tool/system at 0.00 Vdc?	,
Has the been commanded	Use the tool software to verify.
off by an active "valve	
closed" input?	
2. Flow out of range.	
Is the gas inlet/outlet pressure differential	Verify that the pressure is correct for the gas
either too high or too low?	and range. If required, adjust inlet/outlet pressure
	to achieve proper pressure reading.
NOTE: If the differential pressure is too high,	
voltage to the will be zero, which is	
abnormally low for the setpoint. If the	
differential is too low, voltage to will	
be at its maximum value, which is abnormally	
high for the set-point.	
Is the MOD LED light on the GF100 Series	Observe the LED display panel at top of .
lit solid green?	If the LED light is not lit, cycle power the to
It solid green!	reboot.
Is the setpoint correct for the	Use the tool software to verify.
•	
required gas flow? Is the calibrated for the	Check the side label. Run a
particular gas?	flow check to verify.
Is the zero correct?	Zero the according to zeroing
	procedure in Section 2-14. Verify leak check rates
	are OK.
3. No gas control; flow is at or	
above maximum.	
Is the gas pressure across the	Verify that the pressure is correct for the gas and
too high?	range. If required, adjust inlet/outlet pressure to
	achieve proper pressure reading.
Are system valves open, or is the	Use tool software to verify.
purge input activated?	
Is the setpoint correct for the	Use tool software to verify.
required flow?	

Table 4-2 GF100 Series Troubleshooting Guide (Contin	
Symptoms & Possible Causes	Corrective Action
4. No gas flow above some set-point.	
NOTE: When the setpoint is	
increased beyond this point,	
the GF100 Series signal remains at	
some value lower than the set-point.	
Is the gas inlet/outlet differential	Verify that the pressure is correct for
pressure sufficient?	the gas and range. If required, adjust
	regulator to achieve proper pressure
NOTE: If the pressure reading is too low,	
the valve voltage to the GF100 Series	
will be at its maximum output. This condition	
will cause internal GF valve heating and	
inability to properly reach desired flow setpoints.	
Is the GF100 Series calibrated for the	Check GF100 Series side label. Run a flow check to verify.
gas flow?	If flow is incorrect, replace the GF100 Series with a unit that
	is calibrated properly.
5. No gas flow below some set-point.	
NOTE: When the setpoint is	
decreased below this point, the	
GF100 Series signal remains at	
some value higher than the	
setpoint.	
Setpont.	
Is the gas inlet/outlet differential	Verify that the pressure is correct for
pressure too high, or above published	this gas and range. If required, adjust
setpoints?	regulator to achieve proper pressure
selpoints?	l regulator to achieve proper pressure
NOTE: If the differential procesure reading	
NOTE: If the differential pressure reading.	
is too high, voltage to the	
GF100 Series will be at its maximum	
value when the setpoint is	
decreased below the point	
where flow decreases.	Check for contomination Test the OF400 Device
Is the GF100 Series leaking?	Check for contamination. Test the GF100 Series
	for leak integrity. Replace the Unit
	GF100 Series if leakage is detected.
6. Gas flow, or GF100 Series pressure	
reading oscillates.	
Is the GF100 Series calibrated for the	Check the GF100 Series side can label. Run
gas flowing?	a flow check to verify. If flow is incorrect,
	replace the GF100 Series.
Is there too much gas pressure	Verify that the pressure is correct for
across the GF100 Series?	this gas and range. If required, adjust
	regulator to achieve proper pressure
	reading.

Table 4-2 GF100 Series Troubleshooting Guide (Continued)

Symptoms & Possible Causes	Corrective Action
6. Gas flow, or GF100 Series pressure reading oscillates.	
Are inlet and outlet pressures stable?	If outlet pressure is unstable, check for (no oscillation or hunting) a faulty vacuum pump, or hunting at a downstream valve.
NOTE: Most GF100 Series calibrated with nitrogen will oscillate with hydrogen or helium.	Check inlet pressure on tool. A faulty pressure regulator can make the GF100 Series appear to oscillate.
	Adjust inlet pressure up or down by 2 psig increments until hunting disappears. Verify common gas pressure is within range.
	NOTE: Hunting or oscillation can be contributed to multiple GF100 Series sharing a common gas manifold. Therefore, inspect gas delivery sources to the gas box. (for example; two tools sharing a common gas bottle and calling for gas at the same time.) Valve leak. Unregulated gas pressure from Facilities.
7. GF100 Series does not read zero pressure when gas is shut off.	
Is the differential pressure across the GF100 Series really zero?	Verify that the pressure is correct for the gas and range. If the GF100 Series has been contaminated, it may not be able to close, and therefore, will not zero. Equalize the pressure across the GF100 Series by opening it briefly. Set up the GF100 Series for zeroing. Then perform the zeroing procedure in Section 2-14.
Is the GF100 Series configured properly in the tool software?	Use the tool software to verify.
Is the GF100 Series mounted to the proper attitude?	Refer to the side can label on the GF100 Series. The GF100 Series should be calibrated in the attitude it will be operating at.
8. OEM tool does not read correct GF100 Series zero reading.	
Is the differential pressure across the GF100 Series really zero? Is the supply voltage within specified range? Is the GF100 Series mounted in the proper attitude? Is the flow output signal of the GF100 Series really zero?	GF100 Series valve leakage. Incorrect MFC zero.
9. Zero Drift.	
Improper zero of the GF100 Series? Excessive Valve leakage?	GF100 Series aging or sensor stabilization. Zero is not correct.

Table 4-2 GF100 Series Troubleshooting Guide (Continued)

Table 4-2 GF100 Series Troubleshooting Guide (Continued)

Symptoms & Possible Causes	Corrective Action
10. Calibration Drift.	
Gas box temperature too high? Is it linear offset?	Zero is not correct.
11. GF100 Series indicates Overshoot.	
	If the tool is idle for an extended period of time, high inlet pressure or contamination will cause overshoot on first use.
12.OEM tool indicates the wrong full scale value for GF100 Series.	
	Older version of Multiflo Configurator used
	to program GF100 Series.
13. GF100 Series dumps large volume of gas into chamber when setpoint is commanded from the tool.	
	The tool is commanding a setpoint before the pneumatic valves are opened.
	GF100 Series and pneumatic timing may be offset. GF100 Series overshoots.
14. Tool display output doesn't match GF100 Series flow output.	
Cable resistance causing offset in the tool's display.	Check GF100 Series zero.

Overview

Reference Tables 5-1 through 5-5 for specific Product Description Codes.

Table 5-1 GF100, GF120 & GF125 Series Product Description Code

Code D	Description	Code Option	Option Description
Ι.	Base Model Code	GF	High Purity/Ultra High Purity Digital Mass Flow Controllers
II.	Package / Finish Specifications	100	Flow range 3 sccm -55 slpm N $_{2}$ Eq.; \pm 1.0% SP Accuracy; 1 sec Response; 10 Ra
		120	Flow range 3 sccm -55 slpm N, Eq.; + 1.0% SP Accuracy; 700 msec Response; 4 Ra
	Γ	125	Pressure Transient Insensitive (PTI) Flow range 3 sccm -55 slpm N, Eq.; + 1.0% SP Accuracy;
			300-700 msec Response; 4 Ra
III.	Configurability	C	MultiFlo capable. Standard bins or specific gas/range may be selected.
		X	Not MultiFlo capable. Specific gas/range required. (must select w/ SD, SL or HA special application)
IV.	Special Application	XX	Standard
		SL	Safe Delivery System (GF120 Only) Full scale flow range; 4 to 25 sccm, Nitrogen Equivalent
		SD	Safe Delivery System (GF120 Only) Full scale flow range; >25 sccm to 1 slpm, Nitrogen Equivalent
٧.	Valve Configuration	0	Normally Open valve (not available with SD, SL or HA options)
		C	Normally Closed valve (must select with SD, SL or HA special application)
		M	Meter (No Valve)
VI.	Gas or SH MultiFlo Bin	XXXX XXXX	Specific Gas Code & Range, i.e. "0004" = Argon and "010L" = 10 slpm (must select w/ SD, SL or
			HA special application).
		SH40 010C	Standard Configuration #40, 3-10 sccm Nitrogen Equivalent (0° C Reference)
		SH41 030C	Standard Configuration #41, 11-30 sccm Nitrogen Equivalent (0° C Reference)
		SH42 092C	Standard Configuration #42, 31-92 sccm Nitrogen Equivalent (0° C Reference)
		SH43 280C	Standard Configuration #43,93-280 sccm Nitrogen Equivalent (0° C Reference)
		SH44 860C	Standard Configuration #44, 281-860 sccm Nitrogen Equivalent (0° C Reference)
		SH45 2.6L	Standard Configuration #45, 861-2600 sccm Nitrogen Equivalent (0° C Reference)
		SH46 7.2L	Standard Configuration #46, 2601-7200 sccm Nitrogen Equivalent (0° C Reference)
		SH47 015L	Standard Configuration #47, 7201-15000 sccm Nitrogen Equivalent (0° C Reference)
	_	SH48 030L	Standard Configuration #48, 15001-30000 sccm Nitrogen Equivalent (0° C Reference)
		SH49 040L	Standard Configuration #49, 30001-40000 sccm Nitrogen Equivalent (0° C Reference)
		SH50 055L	Standard Configuration #50, 40001-55000 sccm Nitrogen Equivalent (0° C Reference)
VII.	Fitting	VX	1-1/2" body width, 124mm 1/4" VCR male
		VS	1-1/8″ body width, 124mm 1/4″ VCR male
		СХ	1-1/8″ body width, 92mm C Seal
		DX	1-1/8" body width, 79.8mm C Seal
		EX	1-1/2" body width, 79.8mm W Seal
		WX	1-1/8″ body width, 92mm W Seal
		YX	1-1/8" body width, 79.8mm W Seal
		AX	1-1/2" body width, 92mm C Seal
		BX	1-1/2" body width, 92mm W Seal
	-	LX	1-1/8" body width, 92mm C Seal w/Poke Yoke
		AS	1-1/2" body width, 92mm 0.440" large bore C Seal (only for bins SH45-SH50)
VIII.	Downstream Condition	Α	Atmosphere
		V	Vacuum; Default for SD, SL and HA special application
IX.	Sensor	0	Default Sensor Orientation
			Madel Code continued on part page

Model Code continued on next page.

Section 5 Product Description Code

Code Description	Code Option		Option De	scription													
X. Connector	BX	Cable adapt	er to 15 pin D	Brooks (U	nit "B", "N") adapts G1	base										
	EX	Cable adapt	er to Card Edg	je (w/out V	TP), RS485	through R]1	1 jacks (Un	it"E"; IN "	L", "R") ada	pts GX base							
		(Not Available on 79.8mm fitting DX, YX, EX)															
	FX	Cable adapter with 9 pin STEC pin-out & jack screws (w/VTP) (Unit"F", "O") adapts SX base															
	GX	9-Pin D with RS485 (Unit"G"); display and overlay 180° orientation (Not Available on 79.8mm fitting DX, YX, EX)															
	G1	9-Pin D with	Pin D with RS485 (Unit"G") (Not Available on 79.8mm fitting DX, YX, EX)														
	JX	Cable adapt	er with 9 pin S	STEC pin-ou	(Unit"]","\	N") adapts	SX base										
	КХ	Cable adapt	er to MKS 15-	Pin D (Unit	: "K") adapt	ts G1 base											
	SX	9 pin D with	STEC pin-out	(w/VTP) (U	nit"S","Q")												
	ТХ	9 pin D with	uDT9 pin-ou	t (UDT9)													
	T1	Cable adapt	er to 15 pin D	(IFlow DB	15 & TN 15	pin) adapts	TX base (N	ot Availabl	le on 79.8m	m fitting DX	, YX, EX)						
	UX	Cable adapt	er to 15 pin D	(w/VTP) (L	Jnit & TN "l	J") adapts S	X base										
	BB	DeviceNet™	DeviceNet [™] Analog (Not Available on 79.8mm fitting DX, YX, EX)														
	DeviceNet Standard Configuration Parar									ameters							
	Poll IO					Poll IO	Poll IO	External									
		Power On	Full Scale	Full Scale	Full Scale	Instance	Instance	State	Baud								
		I/O	Connector	State	Setting	Setting	Setting	Producer	Consumer	Transition	Rate						
	DO	DeviceNet	5 Pin Micro	Idle	Count	Integer	6000h	2	7	Executing	500KB						
	D1	DeviceNet	5 Pin Micro	Idle	Count	Integer	6000h	21	7	Executing	500KB						
	D2	DeviceNet	5 Pin Micro	Idle	SCCM	Float	7FFFh	13	19	Executing	500KB						
	D3	DeviceNet	5 Pin Micro	Idle	Count	Integer	6000h	22	7	Executing	500KB						
	D4	DeviceNet	5 Pin Micro	Executing	Count	Integer	6000h	22	8	Executing	500KB						
	D5	DeviceNet	5 Pin Micro	Idle	Count	Integer	6000h	6	8	Executing	500KB						
	D6	DeviceNet	5 Pin Micro	Idle	Count	Integer	7FFFh	3	7	Executing	500KB						
	D7	DeviceNet	5 Pin Micro	Idle	Count	Integer	7FFFh	6	8	Executing	500KB						
	D8	DeviceNet	5 Pin Micro	Idle	Count	Integer	6000h	3	7	Executing	500KB						
	D9	DeviceNet	5 Pin Micro	Executing	Count	Integer	6000h	2	7	Executing	500KB						
	DA	DeviceNet	5 Pin Micro	Idle	Count	Integer	7FFFh	22	7	Executing	500KB						
	DB	DeviceNet	5 Pin Micro	Idle	Count	Integer	6000h	22	8	Executing	500KB						
	DC	DeviceNet	5 Pin Micro	Idle	Count	Integer	7FFFh	3	7	Idle	500KB						
	DD	DeviceNet	5 Pin Micro	Executing	Count	Integer	7FFFh	22	8	Executing	500KB						
	DE	DeviceNet	5 Pin Micro	Executing	Sccm	Float	6000h	15	19	Executing	500KB						
	DX	DeviceNet	5 Pin Micro	To be defin	ned by CSR						1						

Table 5-1 GF100, GF120 & GF125 Series Product Description Code (Continued)

Code [Description	Code Option	Option Description
XI.	Customer Special Request	XXXX	Customer Special Request Number; required with "DX, BB" Conn. Option to define DNet settings
XII.	Auto Shut-Off	Α	Auto Shut-Off (Included) Default for SD and SL special application
		X	Auto Shut-Off (Not Included) (Must be selected for meter)
XIII. Auto Zero X		X	Auto Zero (Not Included)
XIV.	Reference Temperature	000	0°C Reference Calibration (Standard) - Default Setting

Sample Standard Model Code

1	II	III	IV	٧		VI		VII	VIII	IX	Х		XI	XII	XIII		XIV
GF	100	C	XX	Μ	-	SH40010C	-	VX	Α	0	GX	-	XXXX	Α	X	-	000

Sample Safe Delivery System (SDS) Model Code

1		III	IV	۷		VI		VII	VIII	IX	X		XI	XII	XIII		XIV
GF	120	X	SD	С	-	XXXXXXXX	-	EX	٧	0	SX	-	XXXX	A	X	-	000

Code D	escription	Code Option	Option Description
١.	Base Model Code	GF	High Purity/Ultra High Purity Digital Mass Flow Controllers
П.	Package / Finish Specifications	100	Flow range 3 sccm - 55 slpm N2 Equivalent.; 1 sec Response; 10 Ra
	i actuge / i mon specifications	120	Flow range 3 sccm - 55 slpm N2 Equivalent.; 700 msec Response; 5 Ra
		125	Pressure Transient Insensitive (PTI) Flow range 3 sccm -55 slpm N2 Equivalent;
			300-700 msec Response; 5 Ra
.	Configurability	C	MultiFlo capable. Standard bins or specific gas/range may be selected.
		X	Not MultiFlo capable. Specific gas/range required. (must select w/ SD or SL special application)
IV.	Special Application	XX	Standard
		SL	Safe Delivery System (GF120 Only) Full scale flow range; 4 to 25 sccm, N2 Equivalent
		SD	Safe Delivery System (GF120 Only) Full scale flow range; 25 sccm to 1 slpm, N2 Equivalent
٧.	Valve Configuration	0	Normally Open valve (not available with SD, SL or VS options)
۰.	value configuration	c	Normally Closed valve
		M	Meter (No Valve)
			•
VI.	Gas or SH MultiFlo Bin	XXXX XXXX	Specific Gas Code & Range, i.e. "0004" = Argon and "010L" = 10 slpm
		SH40 010C	Standard Configuration #40, 3-10 sccm Nitrogen Equivalent
		SH41 030C SH42 092C	Standard Configuration #41, 11-30 sccm Nitrogen Equivalent Standard Configuration #42, 31-92 sccm Nitrogen Equivalent
		SH43 280C	Standard Configuration #42, 51-92 sccm Nitrogen Equivalent
		SH44 860C	Standard Configuration #45,75-200 sccm Nitrogen Equivalent
		SH45 2.6L	Standard Configuration #44, 201 000 sectin Nitrogen Equivalent
		SH46 7.2L	Standard Configuration #46, 2601-7200 sccm Nitrogen Equivalent
		SH47 015L	Standard Configuration #47, 7201-15000 sccm Nitrogen Equivalent
		SH48 030L	Standard Configuration #48, 15001-30000 sccm Nitrogen Equivalent
		SH49 040L	Standard Configuration #49, 30001-40000 sccm Nitrogen Equivalent
		SH50 055L	Standard Configuration #50, 40001-55000 sccm Nitrogen Equivalent
VII.	Fitting	VS	1-1/8" body width, 1/4" VCR male
		VX	1-1/2" body width, 1/4" VCR male
		СХ	1-1/8" body width, C Seal 92mm
		WX	1-1/8" body width, W Seal 92mm
VIII	Downstream Condition	A	Atmosphere
•		v	Vacuum
		-	
IX.	Sensor	0	Default Sensor Orientation
Х.	Connector	EO	EtherCAT Communication
XI.	Customer Special Request	XXXX	Customer Special Request Number
XII.	Auto Shut-Off	A	Auto Shut-Off (Included)
		X	Auto Shut-Off (Not Included)
XIII.	Auto Zero	X	Auto Zero (Not Included)
XIV.	Reference Temperature	000	0 deg C Reference Calibration (Standard) - Default Setting

Table 5-2 GF100, GF120 & GF125 Series with EtherCAT Communications Product Description Code

Table 5-3 Model GF135 Product Description Code
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I. Base Model Code	inishSpecifications 135 Pressure Transient Insensitive (PTI) Ultra High Purity Advanced Diagnostic MFC rability X Gas specific Application XX Standard Application figuration C Normally Closed Valve as Code & Range, XXXXXXX Specify Gas Code & Range, i.e. "0004" = Argon and "010L" = 10 slpm VX 1 1/2" VCR 1/4" CX 1 1/8" C Seal 92mm VX 1 1/8" W Seal 92mm (FUTURE RELEASE) tream Condition A Atmosphere V Vacuum O Default Orientation O DeciceNet 5 Pin Micro Idle Count Integer 6000h 22 7 Executing 50 D3 DeviceNet 5 Pin Micro Idle Count Integer 6000h 21 7 Executing 50 D3 DeviceNet 5 Pin Micro Idle Count Integer 6000h 22 7 Executing 50 D4 DeviceNet 5 Pin Micro Idle Count Integer 6000h 22 7 Executing 50 D5 DeviceNet 5 Pin Micro Idle Count Integer 6000h 22 7 Executing 50 D6 DeviceNet 5 Pin Micro Idle Count Integer 6000h 22 7 Executing 50 D7 DeviceNet 5 Pin Micro Idle Count Integer 6000h 22 7 Executing 50 D6 DeviceNet 5 Pin Micro Idle Count Integer 6000h 22 7 Executing 50 D7 DeviceNet 5 Pin Micro Idle Count Integer 6000h 22 7 Executing 50 D6 DeviceNet 5 Pin Micro Idle Count Integer 6000h 22 7 Executing 50 D6 DeviceNet 5 Pin Micro Idle Count Integer 6000h 22 7 Executing 50 D7 DeviceNet 5 Pin Micro Idle Count Integer 6000h 22 7 Executing 50 D6 DeviceNet 5 Pin Micro Idle Count Integer 6000h 22 7 Executing 50 D7 DeviceNet 5 Pin Micro Idle Count Integer 6000h 22 7 Executing 50 D6 DeviceNet 5 Pin Micro Idle Count Integer 6000h 22 7 Executing 50 D7 DeviceNet 5 Pin Micro Idle Count Integer 7FFFh 3 77 Executing 50 D7 DeviceNet 5 Pin Micro Idle Count Integer 7FFFh 22 77 Executing 50 D8 DeviceNet 5 Pin Micro Idle Count Integer 7FFFh 22 77 Executing 50 D9 DA DeviceNet 5 Pin Micro Idle Count Integer 7FFFh 3 77 Executing 50 D7 DeviceNet 5 Pin Micro Idle Count Integer 7FFFh 3 77 Executing 50 D7 DeviceNet 5 Pin Micro Idle Count Integer 7FFFh 22 77 Executing 50 D8 DeviceNet 5 Pin Micro Idle Count Integer 7FFFh 3														
• Dase model code	e GF pecifications 135 Pressure Transient Insensitive (PTI) Ultra High Purity Advanced Diagnostic MFC // X Gas specific stion XX Standard Application tion C Normally Closed Valve e & Range, XXXXXXXX Specify Gas Code & Range, i.e. "0004" = Argon and "0101" = 10 slpm VX 1 1/2" VCR 1/4" VCR CX 1 1/8" C Seal 92mm VX WX 1 1/8" C Seal 92mm VX V Vacuum Vacuum DeviceNet Standard Configuration Parameters V Vacuum Vacuum DeviceNet Standard Configuration Parameters I/O Connector Full Scale Full Scale Pull 10 Poll 10 State JD1 DeviceNet 5 Pin Micro Idle Count Integer 6000h 21 7 Executing 5														
II. Package/FinishSpecifications	GF tions 135 Pressure Transient Insensitive (PTI) Ultra High Purity Advanced Diagnostic MFC X Gas specific XX Standard Application C Normally Closed Valve nge, XXXX XXX Specify Gas Code & Range, i.e. "0004" = Argon and "010L" = 10 slpm VX 1 1/2" VCR 1/4" CX 1 1/3" C Seal 92mm WX 1 1/3" V Seal 92mm WX 1 1/3" W Seal 92mm (FUTURE RELEASE) V Vacuum O Default Orientation DeviceNet Standard Configuration Parameters V Vacuum D0 DeviceNet State Setting Setting Setting Setting Setting D1 DeviceNet S Pin Micro J1 DeviceNet S Pin Micro J1 Setting Setting Setting Setting J1 DeviceNet S Pin Micro J10 DeviceNet S Pin Micro J10 DeviceNet S Pin Micro J10 DeviceNet S Pin Micro														
III. Configurability	GF														
IV. Special Application	GF Image: Standard Application X Gas specific XX Standard Application C Normally Closed Valve XX Specify Gas Code & Range, i.e. "0004" = Argon and "010L" = 10 slpm VX 1 1/2" VCR 1/4" CX 1 1/2" VCR 1/4" CX 1 1/8" C Seal 92mm WX 1 1/8" W Seal 92mm (FUTURE RELEASE) A Atmosphere V Vacuum O Default Orientation DeviceNet S Pin Micro JO DeviceNet State Setting Setting Full Scale Setting Setting Producer Consumer JO DeviceNet State Setting Setting Setting Producer Consumer JO DeviceNet State Setting Setting Setting Producer Setting JO DeviceNet State Setting Setting Setting Setting <t< th=""></t<>														
V.Valve Configuration	135 Pressure Transient Insensitive (PTI) Ultra High Purity Advanced Diagnostic MFC X Gas specific XX Standard Application C Normally Closed Valve Value Value Value VX 1 1/2" VCR 1/4" CX Specify Gas Code & Range, i.e. "0004" = Argon and "010L" = 10 slpm VX 1 1/2" VCR 1/4" Value Value Value VX 1 1/8" C Seal 92mm ELEASE) Value Value A Atmosphere Vacuum Vacuum Poll 10 Poll 10 Poll 10 State V Vacuum DeviceNet Standard Configuration Parameters Poll 10 Instance State D0 DeviceNet 5 Pin Micro Idle Count Integer 6000h 2 7 Executing D1 DeviceNet 5 Pin Micro Idle Count Integer 6000h 21 7 Executing D3 DeviceNet 5 Pin Micro Idle Count Integer 6000h 21 7 Executing D4 DeviceNet 5 Pin Micro Idle <t< th=""></t<>														
VI. Specific Gas Code & Range,	XXXX XXXX	C Normally Closed Valve XXX XXXX Specify Gas Code & Range, i.e. "0004" = Argon and "010L" = 10 slpm VX 1 1/2" VCR 1/4" CX 1 1/8" C Seal 92mm WX 1 1/8" W Seal 92mm (FUTURE RELEASE) A Atmosphere V Vacuum O Default Orientation DeviceNet Standard Configuration Parameters I/O Connector Full Scale Setting Full Scale Setting Poll 10 Poll 10 Poll 10 State Transition D0 DeviceNet 5 Pin Micro Idle Count Integer 6000h 2 7 Executing D1 DeviceNet 5 Pin Micro Idle Count Integer 6000h 21 7 Executing													
VII. Fitting	VX	1 1/2" VC	R 1/4"												
	СХ	1 1/8" C S	ieal 92mm												
	WX	1 1/8" W	Seal 92mm (F	UTURE REL	EASE)										
VIII. Downstream Condition	Α	Atmosphe	re												
	V	Vacuum													
IX. Sensor	0	Default O	rientation												
X. Connector	Power On Full Scale Full Scale Full Scale Instance Instance State														
	VVacuumODefault OrientationImage: DeviceNet Standard Configuration ParametersImage: DeviceNet Standard Configuration ParametersImage: DeviceNet StateFull ScaleFull ScaleFull ScalePoll 10Poll 10Poll 10Poll 10Poll 10StateStateImage: DeviceNet StateSettingSettingSettingSettingSettingSettingPoducerPoducerTransitionStateImage: DeviceNet StateSpin MicroIdleCountInteger6000h217ExecutingImage: DeviceNet StateSpin MicroIdleSCCMFloat7FFFh1319ExecutingImage: DeviceNet StateSpin MicroIdleCountInteger6000h227ExecutingImage: DeviceN														
	WX 1 1/8" W Seal 92mm (FUTURE RELEASE) Adition A Atmosphere V Vacuum O Default Orientation Image: Notation of the state of the														
-	CX 1 1/8" C Seal 92mm (FUTURE RELEASE) MX 1 1/8" W Seal 92mm (FUTURE RELEASE) On A Atmosphere V Vacuum O Default Orientation Image: Notation of the state of the sta														
-	CX1 1/8" C Seal 92mm (FUTURE RELEASE)AAtmosphereVVacuumODefault OrientationDeviceNet Standard Configuration ParametersImage: Display transform of the transform of the transform of t														
	I/OPower On StateFull Scale SettingFull Scale SettingInstance SettingInstance ConsumerState TransitionFull StateD0DeviceNet5 Pin MicroIdleCountInteger6000h27Executing50D1DeviceNet5 Pin MicroIdleCountInteger6000h217Executing50D2DeviceNet5 Pin MicroIdleSCCMFloat7FFFh1319Executing50D3DeviceNet5 Pin MicroIdleCountInteger6000h227Executing50														
	D4	DeviceNet	5 Pin Micro	Executing	Count	Integer	6000h	22	8	Executing	500KB				
	D5	DeviceNet	5 Pin Micro	Idle	Count	Integer	6000h	6	8	Executing	500KB				
	D6	DeviceNet	5 Pin Micro	Idle	Count	Integer	7FFFh	3	7	Executing	500KB				
	D7	DeviceNet	5 Pin Micro	Idle	Count	Integer	7FFFh	6	8	Executing	500KB				
-	D8	DeviceNet	5 Pin Micro	Idle	Count	Integer	6000h	3	7	Executing	500KB				
	D9	DeviceNet	5 Pin Micro	Executing	Count	Integer	6000h	2	7	Executing	500KB				
	DA	DeviceNet	5 Pin Micro	Idle	Count	Integer	7FFFh	22	7	Executing	500KB				
	DB	DeviceNet	5 Pin Micro	Idle	Count	Integer	6000h	22	8	Executing	500KB				
	DC	DeviceNet	5 Pin Micro	Idle	Count	Integer	7FFFh	3	7	Idle	500KB				
	DD	DeviceNet	5 Pin Micro	Executing	Count	Integer	7FFFh	22	8	Executing	500KB				
	DE	DeviceNet	5 Pin Micro	Executing	SCCM	Float	6000h	15	19	Executing	500KB				
	DX	DeviceNet	5 Pin Micro	To be defi	ned by CSR										
	G2	Analog/RS485	9 Pin D	NA	NA	NA	NA	NA	NA	NA	NA				
XI. Customer Special Request	XXXX	Customer	Special Requ	est Number											

XI. Customer Special Request	XXXX	Customer Special Request Number
XII. Auto Shut-Off	Α	Auto Shut Off (Included)
	X	Auto Shut Off (Not Included)
XIII. Auto Zero	Α	Auto Zero (Included)
	X	Auto Zero (Not Included)
XIV. Reference Temperature	000	0°C Reference Calibration (Standard) - Default Setting

	Examp	ole Mod	el Code	5										
	1			IV	V	VI	VII	VIII	IX	Х	XI	XII	XIII	XIV
[GF	135	Х	XX	C	XXXX XXXX	VX	Α	0	D1	XXXX	Α	Α	000

de D	Description Base Model Code		Code Option GF	Option De High Purit		h Purity Dig	gital Mass Fl	ow Controll	lers			
П.	Package / Finish Spe	cifications	101	Flow range	e 55 - 300	slm N, Eq.;	10 Ra HP w	vetted flow	path			
	5 .		121				5 Ra UHP w					
			126	Flow range	e 55 - 300	slm N ₂ Eq.	5 Ra UHP w	etted flow p	path & inte	grated press	ure measure	ment
III.	Configurability		C	MultiFlo c	apable							
			X	Not config	jurable							
IV.	Special Application		XX	Standard								
۷.	Valve Configuration		C		Closed valve	2						
۷.	valve configuration		M	Meter (No		<u> </u>						
):					"0004" A		1001 // 10			
VI.	Gas or SH MultiFlo B	510	XXXX XXXX SH51 055L				"0004" = A ,001 sccm N					
			51151 0552							0,002-170,0	00 H2	
			SH52 100L							t (0°C Refer		
			SH53 200L							nt (0°C Refe		
			SH54 300L	Standard	Configuratio	on #54, 20	0,001-300,	000 N2 Equ	uivalent (0°	°C Reference)	
VII.	Fitting		V1	1-1/2" bo	dv width. 1	34mm 1/2"	VCR male (See Access	ories on Pa	ae 3 for VCE	R lay length a	adapters
			V2				2" VCR mal			<u> </u>	· · · · · · · · · · · · · · · · · · ·	
			V3		dy width, 1							
			V4				2″ VCR mal	e				
			<u>C1</u>		dy width, 92							
			C2		dy width, 1	14mm 3/8"	C Seal					
VIII.	Downstream Conditi	on	A	Atmosphe	re							
			V	Vacuum								
IX.	Sensor		0	Default Se	ensor Orient	ation						
Х.	Connector	BX	Cable adapte	er to 15 pin D	Brooks (Ur	nit "B"."N")					
		EX	·	er to card edg				1 jacks (Un	it"F": IN "I	". "R"):		
				overlay 180° (. ,,		2 jucito (011		_ / //		
		FX		er with 9 pin 9		t & jack sci	rews (w/VTP)	(Unit"F"."	0″)			
		G1		RS485 (Unit'		,	,		. ,			
		jx		er with 9 pin 9		t & jack sc	rews (w/VTP)) (Unit"1".")	W″)			
		KX		er to MKS 15-	-	-	(1) (1)	(0)() / (,			
		SX	·	STEC pin-out								
		UX		er to 15 pin D								
		UN		.1 to 15 pin b			ard Configu	ration Para	meters			
					Devic				Poll IO	Poll IO	Poll IO	Externa
					Power On	Full Scale	Full Scale	Full Scale	Instance	Instance	State	Baud
			I/O	Connector	State	Setting	Setting	Setting	Producer	Consumer	Transition	Rate
		DO	DeviceNet	5 Pin Micro	Idle	Count	Integer	6000h	2	7	Executing	500KB
		D1	DeviceNet	5 Pin Micro	Idle	Count	Integer	6000h	21	7	Executing	500KB
		D2	DeviceNet	5 Pin Micro	Idle	SCCM	Float	7FFFh	13	19	Executing	500KB
		D3	DeviceNet	5 Pin Micro	Idle	Count	Integer	6000h	22	7	Executing	500KB
		D4	DeviceNet	5 Pin Micro		Count	Integer	6000h	22	8	Executing	500KE
		D5	DeviceNet DeviceNet	5 Pin Micro		Count	Integer	6000h	6	8	Executing	
		D6 D7	DeviceNet DeviceNet	5 Pin Micro 5 Pin Micro	Idle Idle	Count Count	Integer Integer	7FFFh 7FFFh	3 6	7	Executing Executing	500KE
		D7 D8	DeviceNet	5 Pin Micro 5 Pin Micro	Idle	Count	Integer	6000h	6 3	8	Executing	500KE
		D8 D9	DeviceNet	5 Pin Micro		Count	Integer	6000h	2	7	Executing	500KB
		DA	DeviceNet	5 Pin Micro	Idle	Count	Integer	7FFFh	22	7	Executing	500KB
		DB	DeviceNet	5 Pin Micro	Idle	Count	Integer	6000h	22	8	Executing	500KB
		DC	DeviceNet	5 Pin Micro	Idle	Count	Integer	7FFFh	3	7	Idle	500KB
		DD	DeviceNet	5 Pin Micro			Integer	7FFFh	22	8	Executing	500KB
		DE	DeviceNet	5 Pin Micro			Float	6000h	15	19	Executing	500KB
		DX	DeviceNet	5 Pin Micro	Io be defi	ned by CSR						
XI.	Customer Special Re	equest	XXXX	Customer	Special Req	uest Numb	er					
XII.	Auto Shut-Off		A		-Off (Includ							
			X	Auto Shut	-Off (Not In	cluded) (M	ust be selec	ted for met	er)			
XIII.	Auto Zero		A	Auto Zero	(Included)							
			X		(Not Includ	ed)						
XIV.	Reference Temperat	ure	000	0ºC Refere	ence Calibra	tion (Stand	lard) - Defa	ult Setting				
								j				
mple	e Standard Model (or	16										
mple I	Standard Model Cod		V	VI		I IX	X	XI	XII	XIII	XIV	

Table 5-4 GF101, GF121 & GF126 Series Product Description Code

Section 5 Product Description Code

Code D	escription	Code Option	Option Description
Ι.	Base Model Code	GF	High Purity/Ultra High Purity Digital Mass Flow Controllers
II.	Package / Finish Specifications	101	Flow range 55 - 300 slm N2 Equivalent.; 10 Ra HP wetted flow path
		121	Flow range 55 - 300 slm N2 Equivalent 5 Ra HP wetted flow path
		126	Flow range 55 - 300 slm N2 Equivalent 5 Ra HP wetted flow path & integrated pressure measurement
- 111.	Configurability	C	MultiFlo capable. Standard bins or specific gas/range may be selected
		X	Not MultiFlo capable. Specific gas/range required
IV.	Special Application	XX	Standard
۷.	Valve Configuration	C	Normally Closed valve
	-	Μ	Meter (No Valve)
VI.	Gas or SH MultiFlo Bin	XXXX XXXX	Specific Gas Code & Range, i.e. "0004" = Argon and "010L" = 10 slpm
		SH51 055L	Standard Configuration #51, 55,001 sccm N2 Equivalent (0°C Reference)
		SH52 100L	Standard Configuration #52, 55,002-100,000 sccm N2 Equivalent (0°C Reference)
		SH53 200L	Standard Configuration #53, 100,001-200,000 sccm N2 Equivalent (0°C Reference)
		SH54 300L	Standard Configuration #54, 200,001-300,000 N2 Equivalent (0°C Reference)
VII.	Fitting	V1	1-1/2" body width, 134mm 1/2" VCR male
		C1	1-1/2″ body width, 92mm C Seal
		C2	1-1/2″ body width, 114mm C Seal
VIII.	Downstream Condition	Α	Atmosphere
		V	Vacuum
IX.	Sensor	0	Default Sensor Orientation
Χ.	Connector	EO	EtherCAT Communication
XI.	Customer Special Request	XXXX	Customer Special Request (CSR) Number
XII.	Auto Shut-Off	Α	Auto Shut-Off (Included)
		Х	Auto Shut-Off (Not Included)
XIII.	Auto Zero	X	Auto Zero (Not Included)
XIV.	Reference Temperature	000	0°C Reference Calibration (Standard) - Default Setting

Table 5-5 GF101, GF121 & GF126 Series with EtherCAT Communications Product Description Code

GF100 Series Ordering Instructions

Refer to the Product Description Codes on the previous pages. Starting from the left, choose the product code options as follows:

- 1. Required performance model.
 - a. Standard Performance, non-PTI: GF100
 - b. High Performance, non-PTI: GF120
 - c. High Performance, w/ PTI: GF125
 - d. High Performance, w/ PTI, w/ROD: GF135
 - e. Standard Performance, High Flow, Non-PTI: GF101
 - f. High Performance, High Flow, Non-PTI: GF121
 - g. High Performance, High Flow, w/PTI: GF126
- 2. Configurability
 - a. Disabled: X
 - b. Enabled: C, Standard (not an option for GF135)
- 3. Specialty Application
 - a. Safe Delivery, for GF120 only: SD
 - b. No Specialty App: XX
- 4. Valve Configuration
 - a. Normally Closed: C
 - b. Normally Open: O
 - c. Meter: M
- 5. Gas or SH MultiFlo Bin
 - a.If Gas Specific, enter SEMI gas code: ex. 0013, for N2
 - b.If SH MuliFlow Bin: SHnn, nn being the required SHBin, 40 50 or 51 54 (High Flow)
- 6. Maximum Flow
 - a.If Gas Specific, enter maximum range in sccm, "C" or slm "L": ex. 500C
 - b.If SH Bin, enter defined maximum flow: ex. 860, choosing SH44, 281 860 sccm
- 7. Fitting

a.Enter 2-character option code as defined: ex. CX, 1 1/8" C Seal 92mm

- 8. Downstream Condition
 - a.Outlet to Vacuum: V

b.Outlet to Atmosphere: A

9. Sensor

a.Orthogonal: **O**, this is default, non-selectable

10.Connector

a.Enter 2-character option code as defined: ex. DX, DeviceNet

11.CSR

a.Customer Special Requirement, contact Brooks Apps Engineering for review of requirement and creation of CSR: **nnnn**

b.If DNET connector, CSR required to define DNET attributes: **0924**, generic, ODVA Std. configuration c.None Required: **XXXX**

- 12.Auto Shut-Off.
 - a.Enabled: A
 - b.Disabled: X

13.Auto Zero

a.Disabled: X

14.Reference Temperature, Operating Temperature in Degrees C

a.0°C Reference Calibration (Standard): 000, default

Here is an example of a configured Product Description Code (PDC) for a GF125, Configurable, no Specialty Application, Valve Normally Closed, MultiFlo for 281-860 sccm, 1 1/8" C Seal 92mm, outlet to Vacuum, default sensor, DNET, no CSR, Auto Shut Off enabled, Auto Zero disabled and Default Reference Temperature: **GF125CXXC-SH44860C-CXVODX-0924AX-000**

GF100 Series Gas Table

Table A-1 GF100 Series Gas Table

(Reference the following pages, A-1 and A-2).

Gas			Min inlet p	(PSIA	A)			140	SH		_	H42		43	-	144	SH45		146	_	147		148		149		150
Code	Gas Symbol	Gas Name	SH40-SH47	SH48	SH49	SH50	Low	High	Low	High	Low	High	Low	High	Low	High	Low High	Low	High	Low	High	Low	High	Low	High	Low	/ Hię
1	He	Helium	19.7	24.7	29.7		5	14	15	42	43	128	129	400	401	1194	1195 360	3610	11100	11101	23100	23101	47000	47001	100000		
2	Ne	Neon	24.7				5		15	42	43	129	130	400	401	1207	1208 3650	3651	10700	10701	22100						
4	Ar	Argon	24.7	29.7	39.7	44.7	5	14	15	42	43	130	131	400	401	1214	1215 367	3672	10000	10001	20200	20201	41000	41001	42000	42001	550
5	Kr	Krypton	29.7				4		12	32	- 33			300	301	930	931 280	2801	7160	7161	14900						
6	Xe	Xenon	24.7				3	6	5 7	19	20	58	59	178	179	546	547 165	1652	4210	4211	8760						
7	H2	Hydrogen	14.7	14.7	19.7		3	10	11	30	31	92	93	280	281	860	861 260	2601	8000	8001	16400	16401	33000	33001	73000		
	Air	Air	24.7	29.7			3	10	11	30	31	92		280	281	860	861 260	2601	7400	7401	15000	15001	30000				
9	CO	Carbon Monoxide	24.7	29.7			3	10	11	30	31	92	93	280	281	860	861 260	2601	7300	7301	15000	15001	30000				
	HBr	Hydrogen Bromide	24.7				3	8	9	25	26			235	236	723	724 218		5610	5611	11700						
	HCI	Hydrogen Chloride	24.7	29.7			3	10	11	30	31	92	93	280	281	860	861 260	2601	6900	6901	14200	14201	29000				
12	HF	Hydrogen Fluoride	14.7	17.7			3	10	11	30	31	94	95	281	282	880	881 261	2611	7400	7401	15000	15001	30000				
13	N2	Nitrogen	24.7	29.7	29.7	32.7	3	10	11	30	31	92	93	280	281	860	861 260	2601	7200	7201	15000	15001	30000	30001	40000	40001	550
14	D2	Deuterium	14.7	14.7	1		3	10	11	30	31	94	95	280	281	880	881 260	2601	8100	8101	16500	16501	33000				1
15	02	Oxygen	24.7	29.7	29.7	34.7	3	10	11	30	31	92	93	280	281	860	861 260	2601	7200	7201	15000	15001	30000	30001	37000	37001	550
16	NO	Nitric Oxide	24.7	29.7			3	10	11	30	31	92	93	280	281	860	861 260	2601	7200	7201	15000	15001	30000				
17	HI	Hydrogen lodide	24.7	29.7			3	5	6	15	16	46	47	141	142	432	433 130	1306	3340	3341	6960	6961	13900				L
18	F2	Fluorine	24.7	29.7			3	9	10	27	28	83		254	255	780	781 235	3 2359	6700	6701	14000	14001	28000				L
	Cl2	Chlorine	24.7	29.7			3	6	5 7	19	20	57	58	173	174	531	532 160-	1605	4850	4851	10100	10101	20200				L
22	H2S	Hydrogen Sulfide	24.7	29.7			3	8	9	25	26	76	5 77	232	233	713	714 215	2156	5900	5901	12100	12101	24100				L
23	H2Se	Hydrogen Selenide	24.7	29.7			3	7	8	22	23	66	67	202	203	620	621 1874	1875	4770	4771	10000	10001	20000				
25	CO2	Carbon Dioxide	24.7	29.7	29.7	29.7	3	7	8	22	23	69	70	209	210	642	643 1942	2 1943	5300	5301	11000	11001	22000	22001	28000	28001	390
27	N2O	Nitrous Oxide	24.7	29.7	29.7	29.7	3	7	8	21	22	65	66	200	201	611	612 1849	9 1850	5100	5101	10400	10401	21000	21001	25000	25001	370
28	CH4	Methane	24.7	24.7	29.7		3	8	9	23	24	71	72	215	216	660	661 200	2001	5800	5801	12000	12001	24000	24001	46000		
29	NH3	Ammonia	24.7	24.7	29.7		3	8	9	24	25	73	74	223	224	685	686 207	2 2073	6000	6001	12200	12201	25000	25001	46000		
31	PH3	Phosphine	19.7	24.7			3	7	8	22	23	67	68	205	206	629	630 190	1 1902	5200	5201	10700	10701	21300				
32	SO2	Sulfur Dioxide	19.7	24.7			3	6	5 7	17	18	52	53	157	158	483	484 145	9 1460	3800	3801	7920	7921	15800				
33	CH3F	Methyl Fluoride	24.7	29.7			3	7	8	22	23	67	68	204	205	625	626 189	1891	5200	5201	10600	10601	21200				
34	COS	Carbonyl Sulfide	24.7	29.7			3	7	8	20	21	60	61	183	184	562	563 170	1701	4500	4501	9400	9401	18300				
35	AsH3	Arsine	24.7	29.7			3	6	5 7	18	19	55	56	170	171	510	511 1550	1551	4000	4001	8500	8501	17000				
37	CICN	Cyanogen Chloride	14.7	21.7			3	5	6	15	16	46	6 47	142	143	435	436 1320	1321	3400	3401	7060	7061	14100				
38	C2H4	Ethylene	24.7	29.7			3	6	5 7	17	18	54	55	163	164	501	502 1510	5 1517	4400	4401	9300	9301	18200				
39	SiH4	Silane	24.7	29.7			3	6	5 7	18	19	56	57	170	171	523	524 158	1582	4400	4401	9300	9301	18200				
42	C2H2	Acetylene	16.7	19.7			3	6	5 7	18	19	57	58	170	171	530	531 160	1601	4400	4401	9300	9301	18200				
43	GeH4	Germane	24.7	29.7			3	6	5 7	17	18	53	54	161	162	495	496 150	1501	4000	4001	8400	8401	16400				
46	COF2	Carbonyl Fluoride	19.7	19.7	21.7		3	5	6	17	18	53		160	161	500	501 150	1501	4000	4001	8400	8401	16500	16501	21000		
48	BF3	Boron Trifluoride	19.7	24.7			3	5	6	16	17	50	51	150	151	457	458 138	1 1382	3800	3801	7900	7901	15500				
49	CHF3	Fluoroform (Freon-23)	24.7	24.7	24.7	26.7	3		6	16	17			145	146	445	446 134	1345	3600	3601	7600	7601	15000	15001	17000	17001	260
53	NF3	Nitrogen Trifluoride	24.7	29.7	24.7	26.7	3	5	6	15	16	46		140	141	430	431 130	1301	3600	3601	7500	7501	15000	15001	17000	17001	2600
	C2H6	Ethane	17.7	29.7			3		6	16				153	154	469	470 141	3 1419	4000	4001	8300	8301	16300				
	B2H6	Diborane	19.7	19.7			3		5	12				116	117	358	359 108	2 1083	3100	3101	6400	6401	12600				
	COCI2	Phosgene	12.7	14.7			3		4	11				106	107	325	326 100	1001	2520	2521	5250	5251	10500				
	PF3	Phosphorus Trifluoride	19.7	24.7			3		5	14				129	130	400	401 120	1201	3200	3201	6800	6801	13300				
	CF4	Carbon Tetrafluoride (Freon-14)	24.7	24.7	24.7	26.7	3		5	13				121	122	372	373 112	3 1124	3010	3011	6400	6401	12600	12601	17000	17001	220
	SiH2Cl2	Dichlorosilane	14.7	19.7			3		4	10				89	90	273	274 824	4 825	2140	2141	4450	4451	8900				
	C3H6-b)	Propylene	19.7	19.7			3		5	12	13			110	111	338	339 102	2 1023	2800	2801	5900	5901	11700				
	BCl3	Boron Trichloride	11.7	14.7			3		4	10				94	95	289	290 874		2230	2231	4650	4651	9300				
	CIO3F	Perchloryl Fluoride	14.7	20.7			3		5	12				114	115	350	351 106	1061	2800	2801	5800	5801	11500				
	CIF3	Chlorine Trifluoride	14.7	20.7			3		5	11				107	108	327	328 100	1001	2560	2561	5340	5341	10700				
	C2H7N	Dimethylamine	9.7	14.7			3		4	11				101	102	310	311 96	961	2530	2531	5400	5401	10600				
	SiF4	Silicon Tetrafluoride	19.7	24.7			3		5	11				103	104	316	317 100	1001	2600	2601	5400	5401	10600				
	C3H8	Propane	9.7	11.7			3		4	10				100	101	300	301 91		2420	2421	5100	5101	10100				1
	C2F4	Tetrafluoroethylene	19.7	19.7			3	-	4	10		31		100	101	300	301 900	901	2300	2301	4900	4901	9800				1
	Si2H6	DISILANE	19.7	19.7			3		4	10				92	93	282	283 853	854	2300	2301	4900	4901	9800				
	GeF4	Germanium Tetrafluoride	20.7	24.7			3	3	4	10	11			92	93	282	283 86	861	2200	2201	4700	4701	9400				
	C4H8-i)	Butene	20.7	24.7					3	5	6	17		52	53	159	160 480		1420	1421	2950	2951	5900				
108	SiCl4	Silicon Tetrachloride	8.7	1	I –	I –	1 -	1 -	3	6	7	18	19	56	57	172	173 520	521	1320	1321	2750	1	1 -	1 7		4	1 7

Table A-1A GF100 Series Gas Table - Codes 1-108, Bins SH40 to SH50

Appendix A: GF100 Series Gas Table

Gas			Min inlet p	ressure f (PSI/		xhaust	SI	-140	SH	41	SF	H42	SH	143	SH	144	SH	445	SH	146	SH	-147	Sł	148	SH	149	Sŀ	150
ode	Gas Symbol	Gas Name	SH40-SH47	SH48	SH49	SH50	Low	Hiah	Low	High	Low	High	Low	High	Low	High	Low	High	Low	High	Low	High	Low	High	Low	High	Low	/ H
		Trimethylamine	6.7	8.7					3	8	9		26	78	79	240	241		721	1910	1911	4000	4001	8100				T
110	SF6	Sulfur Hexafluoride	19.7	19.7	19.7	20.7			3	8	9	25	26	77	78	237	238	715	716	1900	1901	4000	4001	8000	8001	8200	8201	134
111	C4H10-d)	Isobutane	19.7	19.7	19.7	20.7			3	7	8	23	24	70	71	216	217	653	654	1800	1801	3800	3801	7600	7601	8200	8201	13
117	C4H10-c)	Butane	19.7	19.7	19.7	20.7			3	8	9	25	26	76	77	234	235	706	707	1910	1911	4000	4001	8100	8101	8200	8201	14
118	C2F6	Hexafluoroethane (Freon-116)	19.7	19.7					3	8	9	23	24	71	72	218	219	658	659	1750	1751	3700	3701	7400				t
121	WF6	Tungsten Hexafluoride	9.7	11.7					3	5	6	16	17	50	51	150	151	460	461	1200	1201	2500	2501	5000				┢
128	C3F8	Perfluoropropane	19.7	19.7					3	5	6	16	17	50	51	154	155	465	466	1200	1201	2500	2501	5100				┢
129	C4F8	Octafluorocyclobutane	19.7	19.7					3	5	6	16	17	50	51	154	155	465	466	1170	1171	2430	2431	4900				t
138	C3F6	Hexafluoropropylene	19.7	19.7					3	6	7	20	21	60	61	184	185	556	557	1470	1471	3050	3051	6110				t
155	C2HF5	PENTAFLUOROETHANE (FREC	19.7	19.7					3	8	9	25	26	77	78	235	236	711	712	1900	1901	4000	4001	8000				t
60	CH2F2	Difluoromethane	24.7	29.7			3	6	7	19	20	57	58	174	175	533	534	1612	1613	4300	4301	9000	9001	18000				t
185	CH6Si	Methylsilane (MONO)	9.7	14.7			3	4	5	12	13	37	38	111	112	340	341	1050	1051	2800	2801	5900	5901	11600				t
190	(CH3)3SiH	Trimethylsilane (TMSi)	6.7						3	7	8	20	21	62	63	189	190	572	573	1530	1531	3200						t
266	C5F8	Octafluorocyclopentene	9.7	14.7					3	5	6	14	15	44	45	134	135	406	407	1050	1051	2200	2201	4500				t
270	C4F6	Hexafluoro-2-butyne	9.7						3	6	7	19	20	57	58	176	177	533	534	1400	1401	2900						t
297	C4F6-q)	Hexafluoro Butadiene-1-3	14.7	14.7	1	i			3	6	7	17	18	52	53	160	161	500	501	1270	1271	2640	2641	5270				t
354	C5F80	Epoxyperfluorocyclopentene	19.7	19.7	1	1	1	1	3	4	5	13	14	40	41	122	123	369	370	1000	1001	2100	2101	4200				t
368	Si3H9N	Trisilylamine (TSA)	6.0	7.2	1	i			3	6	7	20	21	60	61	181	182	560	561	1410	1411	3000	3001	6000				t
371	C4H11N	Dimethylethylamine	8.7	8.7	1	1	1	1	3	6	7	20	21	63	64	190	191	580	581	1530	1531	3200	3201	6500				t
509	10%GeH4/H2	10%Germane/Hydrogen	20.7	20.7			3	9	10	28	29	86	87	260	261	800	801	2400	2401	7200	7201	15000	15001	30000				t
516	10%PH3/H2	10%Phosphine/Hydrogen	14.7	14.7			3	9	10	28	29	90	91	275	276	813	814	2500	2501	7600	7601	15500	15501	31000				t
527	10%PH3/N2	10%Phosphine/Nitrogen	19.7	24.7			3	9	10	30	31	91	92	271	272	850	851	2510	2511	7100	7101	14500	14501	29000				t
528	4.5%PH3/N2	4.5%Phosphine/Nitrogen	20.7	29.7			3	10	11	30	31	94	95	280	281	880	881	2600	2601	7200	7201	15000	15001	30000				t
36	20%O2/He	20%Oxygen/Helium	19.7	29.7			4	13	14	38	39	120	121	360	361	1102	1103	3331	3332	10000	10001	21000	21001	42000				t
537	1%PH3/Ar	1%Phosphine/Argon	19.7	29.7		1	5	14	15	42	43	128	129	390	391	1200	1201	3600	3601	9800	9801	20000	20001	40000				Г
542	5%H2/N2	5%Hydrogen/Nitrogen	24.7	29.7		1	3	10	11	30	31	92	93	280	281	860	861	2600	2601	7400	7401	15100	15101	31000				Г
557	1%B2H6/H2	1%Diborane Hydrogen	24.7	29.7		1	3	10	11	30	31	91	92	270	271	850	851	2510	2511	7900	7901	16100	16101	33000				Г
563	1%PH3/H2	1%Phosphine/Hydrogen	19.7	19.7			3	10	11	30	31	90	91	273	274	850	851	2531	2532	7800	7801	16000	16001	32000				t
595	3%B2H6/N2	3%Diborane/Nitrogen	20.7	29.7			3	9	10	29	30	90	91	270	271	850	851	2500	2501	7100	7101	14500	14501	29000				t
597	3%H2/N2	3%Hydrogen/Nitrogen	24.7	29.7		1	3	10	11	30	31	92	93	280	281	860	861	2600	2601	7400	7401	15100	15101	30100				Г
603	30%He/O2	30%Helium/Oxygen	24.7	29.7			4	11	12	33	34	100	101	301	302	950	951	2800	2801	8100	8101	17000	17001	34000				t
604	30%O2/He	30%Oxygen/Helium	19.7	29.7		1	4	12	13	37	38	113	114	345	346	1060	1061	3203	3204	9700	9701	20000	20001	40000				Г
606	4%H2/He	4%Hydrogen/Helium	19.7	19.7		1	5	14	15	41	42	126	127	400	401	1200	1201	3600	3601	11000	11001	23000	23001	46000				Г
607	4%H2/N2	4%Hydrogen/Nitrogen	24.7	29.7		1	3	10	11	30	31	92	93	280	281	860	861	2600	2601	7400	7401	15100	15101	30100				Г
615	5%B2H6/Ar	5%Diborane/Argon	24.7			1	4	12	13	38	39	116	117	353	354	1084	1085	3278	3279	8900	8901	18200		1				Г
626	5%PH3/Ar	5%Phosphine/Argon	27.7	32.7		1	5	13	14	41	42	125	126	380	381	1170	1171	3600	3601	9500	9501	19400	19401	39000				Г
532	50%PH3/SiH4	50%Phosphine/Silane	16.7	24.7		1	3	6	7	20	21	62	63	190	191	580	581	1730	1731	4800	4801	10000	10001	20000				Г
649	10%O2/He	10%Oxygen/Helium	19.7	24.7		1	5	13	14	41	42	123	124	380	381	1150	1151	3500	3501	10500	10501	22000	22001	44000				Г
653	2%SiH4/N2	2%SILANE/NITROGEN	19.7	24.7		1	3	10	11	30	31	93	94	280	281	870	871	2600	2601	7300	7301	15000	15001	30000				Г
654	5%B2H6/N2	5%Diborane/Nitrogen	24.7	29.7		1	3	9	10	28	29	86	87	262	263	804	805	2500	2501	7000	7001	14100	14101	28100				Г
662	.8%B2H6/N2	.8%Diborane/Nitrogen	24.7	29.7		1	3	10	11	30	31	93	94	280	281	870	871	2600	2601	7300	7301	15000	15001	30000				Г
674	10%PH3/He	10%Phosphine/Helium	14.7	19.7			4	13	14	40	41	120	121	370	371	1100	1101	3400	3401	10000	10001	21000	21001	43000				Г
676	7.5%PH3/SiH4	7.5%Phosphine/Silane	14.7	14.7			3	6	7	19	20	58	59	175	176	540	541	1610	1611	4500	4501	9400	9401	18400				Г
693	5%PH3/He	5%Phosphine/Helium	12.7	14.7			4	13	14	41	42	125	126	380	381	1150	1151	3500	3501	10500	10501	22000	22001	44000				Г
695	2%B2H6/N2	2%Diborane/Nitrogen	24.7	29.7			3	10	11	30	31	93	94	280	281	870	871	2600	2601	7200	7201	15000	15001	30000				Г
698	10%GeH4/Ar	10%Germane/Argon	24.7	29.7			4	12	13	38	39	114	115	350	351	1070	1071	3300	3301	8700	8701	18000	18001	36000				Г
00	4%H2/Ar	4%Hydrogen/Argon	24.7	29.7		1	5	14	15	42	43	130	131	390	391	1200	1201	3700	3701	9800	9801	20000	20001	40000				Г
01	10%B2H6/H2	10%Diborane/Hydrogen	14.7	14.7			3	8	9	26	27	81	82	241	242	760	761	2300	2301	7000	7001	14200	14201	29000				Γ
62	5%H2/He	5%Hydrogen/Helium	19.7	19.7			5	14	15	41	42	125	126	400	401	1200	1201	3600	3601	11000	11001	23000	23001	46000				Г
66	5%B2H6/He	5%Diborane/Helium	14.7	16.7			4	12	13	38	39	115	116	350	351	1100	1101	3300	3301	10000	10001	21000	21001	42000				Γ
780	5%SiH4/He	5%Silane/Helium	14.7	16.7			4	13	14	40	41	122	123	380	381	1140	1141	3500	3501	10500	10501	22000	22001	44000				Г
305	1%B2H6/Ar	1%Diborane/Argon	14.7	16.7			5	14	15	42	43	130	131	390	391	1200	1201	3600	3601	9700	9701	20000	20001	40000				Γ
320	15%B2H6/H2	15%Diborane/Hydrogen	14.7	14.7			3	8	9	25	26	76	77	230	231	710	711	2120	2121	6500	6501	13300	13301	27000				Т
324	2%SO2/N2	2%Sulfur Dioxide/Nitrogen	14.7	14.7			3	10	11	30	31	93	94	280	281	870	871	2600	2601	7300	7301	15000	15001	30000				Г
837	30%GeH4/Ar	30%Germane/Argon	14.7	14.7			3	10	11	30	31	93	94	280	281	860	861	2600	2601	6900	6901	14100	14101	28100				Г
276	20%O2/Ar	20%Oxygen/Argon	14.7	14.7	1	1	4	13	14	39	40	120	121	370	371	1120	1121	3400	3401	9200	9201	19000	19001	38000				t

Table A-1B GF100 Series Gas Table - Codes 109-875, Bins SH40 to SH50	Table A-1B	GF100 Series Ga	s Table - Codes 109-875,	Bins SH40 to SH50
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Table A-1C GF100 Series Gas Table - Codes 878-5022, Bins SH40 to SH50

			Min inlet pre	essure f	or vac. ex	khaust																						
Gas				(PSIA	N)		SH	140	SH	141	SH	142	SH	43	SH	44	SH	145	SH	146	SH	147	SH	148	SH	149		150
Code	Gas Symbol	Gas Name	SH40-SH47	SH48	SH49	SH50	Low	High	Low	High	Low	High	Low	High	Low	High	Low	High	Low	r Hig								
878	3%C2H4/He	3%Ethylene/Helium	19.7	19.7			4	13	14	40	41	125	126	375	376	1150	1151	3500	3501	10700	10701	22100	22101	45000				
881	10%B2H6/Ar	5%Diborane/Argon	24.7	29.7	1		4	11	12	35	36	105	106	320	321	1000	1001	3000	3001	8100	8101	17000	17001	34000				
897	2.7%C2H4/He	2.7%Ethylene/Helium	19.7	19.7			4	13	14	40	41	125	126	377	378	1158	1159	3502	3503	10700	10701	22200	22201	45000				
898	1%GeH4/H2	1%Germane/Hydrogen	20.7	20.7			3	10	11	30	31	91	92	275	276	850	851	2530	2531	8000	8001	16200	16201	33000				
		0.5%Germane/Hydrogen	20.7	20.7			3	10	11	30	31	92	93	280	281	860	861	2600	2601	8000	8001	16300		33000				
916		2%Phosphine/Hydrogen	21.7	21.7			3	10	11	30	31	91	92	275	276	850	851	2530	2531	8000	8001	16200		33000				
917		50%Propylene/Nitrogen	19.7	21.7			3	5	6	17	18	53	54	160	161	500	501	1500	1501	4100	4101	8600		17000				
925	10%C3H6-b)/N2	10%Propylene/Nitrogen	19.7	21.7			3	8	9	26	27	82	83	243	244	760	761	2300	2301	6400	6401	13100		26100				
	10%CH4/N2	10%Methane/Nitrogen	19.7	21.7			3	10	11	29	30	91	92	272	273	850	851	2520	2521	7200	7201	15000		30000				
930		3.9%Hydrogen/Nitrogen	24.7	29.7			3	10	11	30	31	92	93	280	281	860	861	2600	2601	7400	7401	15100		30100				
939	10%B2H6/He	10%Diborane/Helium	19.7	19.7			4	11	12	34	35	103	104	314	315	965	966	2918	2919	9000	9001	18400	18401	37000				
946	30%C2H4/He	30%Ethylene/Helium	19.7	24.7			3	10	11	30	31	90	91	275	276	850	851	2551	2552	7800	7801	16000	16001	32000				
950	10%H2/He	10%Hydrogen/Helium	19.7	19.7			4	13	14	40	41	125	126	380	381	1200	1201	3500	3501	10700	10701	22200	22201	45000				
953	15%H2/B2H6	15%Hydrogen/Diborane	19.7	19.7	1		3	4	5	14	15	42	43	130	131	400	401	1200	1201	3400	3401	7100	7101	14000				
958	17%CH4/CO2	17%Methane/Carbon Dioxide	24.7	29.7	1		3	7	8	23	24	70	71	210	211	650	651	2000	2001	5400	5401	11000	11001	22000				
962	20%CH6Si/H2	20%Methylsilane (MONO)/Hydrod	14.7	19.7	1		3	7	8	23	24	71	72	212	213	660	661	2000	2001	5900	5901	12000	12001	24000				
965	50%CH3SiHCl2/H2	50%Dichloromethylsilane/Hydrog	11.7	13.7	1		3	4	5	14	15	42	43	130	131	400	401	1200	1201	3100	3101	6600	6601	13000				
978	20%GeH4/H2	20%Germane/Hydrogen	19.7	24.7			3	8	9	26	27	81	82	241	242	750	751	2240	2241	6600	6601	13500	13501	27000				
979	0.5%B2H6/He	0.5%Diborane/Helium	14.7	19.7			5	14	15	42	43	130	131	400	401	1200	1201	3700	3701	11000	11001	23000	23001	47000				
980	20%F2/Ar	20%Fluorine/Argon	24.7	29.7			4	13	14	39	40	120	121	360	361	1100	1101	3400	3401	9000	9001	18400	18401	37000				
982	5%HF/N2	5%Hydrogen Fluoride/Nitrogen	24.7	29.7			4	10	11	30	31	92	93	280	281	860	861	2600	2601	7200	7201	15000	15001	30000				
		3%Hydrogen Sulfide/Carbon Mon	24.7	29.7			3	10	11	30	31	92	93	280	281	860	861	2600	2601	7200	7201	15000		30000				
984	1.4%C2H2/Ar	1.4%Acetylene/Argon	24.7	29.7			5	14	15	42	43	130	131	390	391	1200	1201	3600	3601	9700	9701	20000	20001	40000				
985	2%Ge2H6/H2	2%Digermane/Hydrogen	24.7	29.7			3	10	11	30	31	92	93	280	281	860	861	2600	2601	7200	7201	15000	15001	30000				
	38%SiCl4/02	38%Silicon Tetrachloride/Oxygen	24.7	29.7	29.7	29.7	3	5	6	16	17	50	51	150	151	460	461	1400	1401	3600	3601	7500	7501		15001	15001	15002	2500
987	20%H2S/20%CO2	20%Hydrogen Sulfide/20%Carbo	24.7	29.7			3	9	10	27	28	85	86	252	253	790	791	2400	2401	6500	6501	13300		27000				
		20%Dichlorosilane/Hydrogen	24.7	29.7			3	8	9	24	25	74	75	222	223	700	701	2100	2101	5900	5901	12000	12001	24000				
		0.1%Chlorine/Nitrogen	24.7	29.7			4	10	11	30	31	94	95	280	281	880	881	2600	2601	7400	7401	15000		30000				t
	1%HCI/N2	1%Hydrogen Chloride/Nitrogen	24.7	29.7			4	10	11	30	31	94	95	280	281	880	881	2600	2601	7400	7401	15000	15001	30000				t
		3%Boron Trichloride/Nitrogen	24.7	29.7			3	.9	10	29	30	91	92	270	271	850	851	2510	2511	7000	7001	14400		29000				t
992	18%NO/N2	18%Nitric Oxide/Nitrogen	24.7	29.7	i –		3	10	11	30	31	94	95	280	281	880	881	2600	2601	7300	7301	15000		30000				<u> </u>
		9%Nitric Oxide/41%Nitrogen/H2	24.7	29.7			4	10	11	30	31	94	95	281	282	880	881	2610	2611	7700	7701	16000		32000				<u> </u>
		20%Hydrogen/Argon	24.7	29.7	-		4	13	14	40	41	120	121	370	371	1120	1121	3400	3401	9400	9401	19200	19201	39000				<u> </u>
		Carbonyl Sulfide (Special)	24.7	29.7			3	7	8	20	21	60	61	183	184	562	563	1700	1701	4500	4501	9400		18300				+
	осо-орена	Sarsaryi Guillus (Opecial)	27.1	23.1			- 3			20		00	01	103	104	502	505	1700	17.01		4001	3400	3401	.0000			<u> </u>	+

GF100 Series Patents

The GF100 Series may be protected by the following US patents and their international filings.

Patent/Pub. No.	Title
6343617	System and method of operation of a digital mass flow controller
6389364	System and method for a digital mass flow controller
6425281	Pressure insensitive gas control system
6445980	System and method for a variable gain proportional-integral (PI) controller
6539792	Method and apparatus for balancing resistance
6640822	System and method of operation of a digital mass flow controller
6681787	System and method of operation of a digital mass flow controller
6714878	System and method for a digital mass flow controller
6752166	Method and apparatus for providing a determined ratio of process fluids
6826953	Flow sensor
6845659	Variable resistance sensor with common reference leg
6910381	System and method of operation of an embedded system
	for a digital capacitance diaphragm gauge
6941965	Method and apparatus for providing a determined ratio of process fluids
6962164	System and method for a mass flow controller
7043374	Flow sensor signal conversion
7073392	Methods and apparatus for pressure compensation in a mass flow controller
7082824	Variable resistance sensor with common reference leg
7113895	System and method for filtering output in mass flow controllers and mass flow meters
7114511	System and method for a mass flow controller
7133785	Valve control system and method
7143774	Method and apparatus for providing a determined ratio of process fluids
7150201	System and method for measuring flow
7216019	Method and system for a mass flow controller with reduced pressure sensitivity
7231931	System and method for a mass flow controller
7243035	System and method for mass flow detection device calibration
7272512	Flow sensor signal conversion
7273063	Methods and apparatus for pressure compensation in a mass flow controller
7287434	System and method for measuring flow
7360551	Method and apparatus for providing a determined ratio of process fluids
7363182	System and method for mass flow detection device calibration
7380564	System and method for a mass flow controller
7409871	Mass flow meter or controller with inclination sensor
7412986	Method and system for flow measurement and validation of a mass flow controller
7424894	Method and apparatus for providing a determined ratio of process fluids
7434477	Methods and apparatus for pressure compensation in a mass flow controller

Table B-1 GF100 Series Patents

LIMITED WARRANTY

Visit www.BrooksInstrument.com for the terms and conditions of our limited warranty.

BROOKS SERVICE AND SUPPORT

Brooks is committed to assuring all of our customers receive the ideal flow solution for their application, along with outstanding service and support to back it up. We operate first class repair facilities located around the world to provide rapid response and support. Each location utilizes primary standard calibration equipment to ensure accuracy and reliability for repairs and recalibration and is certified by our local Weights and Measures Authorities and traceable to the relevant International Standards.

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Brooks Instrument can provide start-up service prior to operation when required.

For some process applications, where ISO-9001 Quality Certification is important, it is mandatory to verify and/or (re)calibrate the products periodically. In many cases this service can be provided under in-situ conditions, and the results will be traceable to the relevant international quality standards.

CUSTOMER SEMINARS AND TRAINING

Brooks Instrument can provide customer seminars and dedicated training to engineers, end users and maintenance persons.

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Due to Brooks Instrument's commitment to continuous improvement of our products, all specifications are subject to change without notice.

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X-TMF-GF100-Series-eng/541B137AAG/2021-06

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